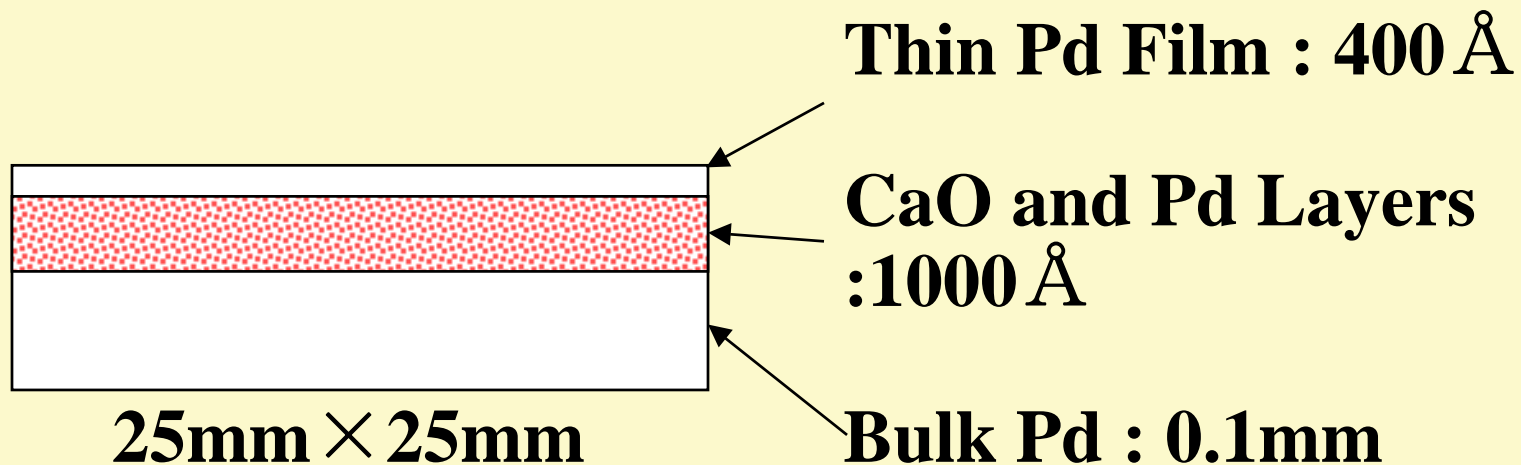


Pd Complex

Pd complex containing CaO



Transmutation of Cs into Pr

元素の周期表

	IA	IIA	IIIA	IVA	VA	VIA	VIIA	VIIIA	IB	IIB	IIIB	IVB	VB	VIB	VII B	0		
1	1 H															2 He		
2	3 Li	4 Be							5 B	6 C	7 N	8 O	9 F	10 Ne				
3	11 Na	12 Mg							13 Al	14 Si	15 P	16 S	17 Cl	18 Ar				
4	19 K	20 Ca	21 Sc	22 Ti	23 V	24 Cr	25 Mn	26 Fe	27 Co	28 Ni	29 Cu	30 Zn	31 Ga	32 Ge	33 As	34 Se	35 Br	36 Kr
5	37 Rb	38 Sr	39 Y	40 Zr	41 Nb	42 Mo	43 Tc	44 Ru	45 Rh	46 Pd	47 Ag	48 Cd	49 In	50 Sn	51 Sb	52 Te	53 I	54 Xe
6	55 Cs	56 Ba	57 L	72 Hf	73 Ta	74 W	75 Re	76 Os	77 Ir	78 Pt	79 Au	80 Hg	81 Tl	82 Pb	83 Bi	84 Po	85 At	86 Rn
7	87 Fr	88 Ra	89 A															
			57 L	58 La	59 Ce	60 Pr	61 Nd	62 Pm	63 Sm	64 Eu	65 Gd	66 Tb	67 Dy	68 Ho	69 Er	70 Tm	71 Yb	Lu
			89 A	90 Ac	91 Th	92 Pa	93 U	94 Np	95 Pu	96 Am	97 Cm	98 Bk	99 Cf	100 Es	101 Fm	102 Md	103 No	Lr

- 典型金属元素
- 半金属元素
- 非金属元素
- 遷移金属元素
- 希ガス

$^{133}_{55}\text{Cs}$

Atomic N. +4
Mass N. +8

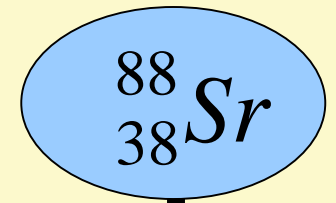
$^{141}_{59}\text{Pr}$

Transmutation of Sr into Mo

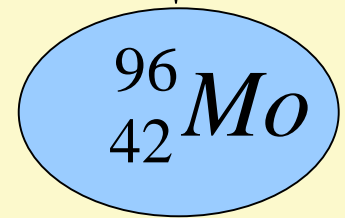
元素の周期表

	IA	IIA	IIIA	IVA	VA	VIA	VIIA	VIIIA	IB	IIB	IIIB	IVB	VB	VIB	VIB	0		
1	1 H															2 He		
2	3 Li	4 Be							5 B	6 C	7 N	8 O	9 F	10 Ne				
3	11 Na	12 Mg							13 Al	14 Si	15 P	16 S	17 Cl	18 Ar				
4	19 K	20 Ca	21 Sc	22 Ti	23 V	24 Cr	25 Mn	26 Fe	27 Co	28 Ni	29 Cu	30 Zn	31 Ga	32 Ge	33 As	34 Se	35 Br	36 Kr
5	37 Rb	38 Sr	39 Y	40 Zr	41 Nb	42 Mo	43 Tc	44 Ru	45 Rh	46 Pd	47 Ag	48 Cd	49 In	50 Sn	51 Sb	52 Te	53 I	54 Xe
6	55 Cs	56 Ba	57 L	72 Hf	73 Ta	74 W	75 Re	76 Os	77 Ir	78 Pt	79 Au	80 Hg	81 Tl	82 Pb	83 Bi	84 Po	85 At	86 Rn
7	87 Fr	88 Ra	89 A															
			57 L	58 La	59 Ce	60 Pr	61 Nd	62 Pm	63 Sm	64 Eu	65 Gd	66 Tb	67 Dy	68 Ho	69 Er	70 Tm	71 Yb	Lu
			89 A	90 Ac	91 Th	92 Pa	93 U	94 Np	95 Pu	96 Am	97 Cm	98 Bk	99 Cf	100 Es	101 Fm	102 Md	103 No	Lr

- 典型金属元素
- 半金属元素
- 非金属元素
- 遷移金属元素
- 希ガス



Atomic N. +4
Mass N. +8

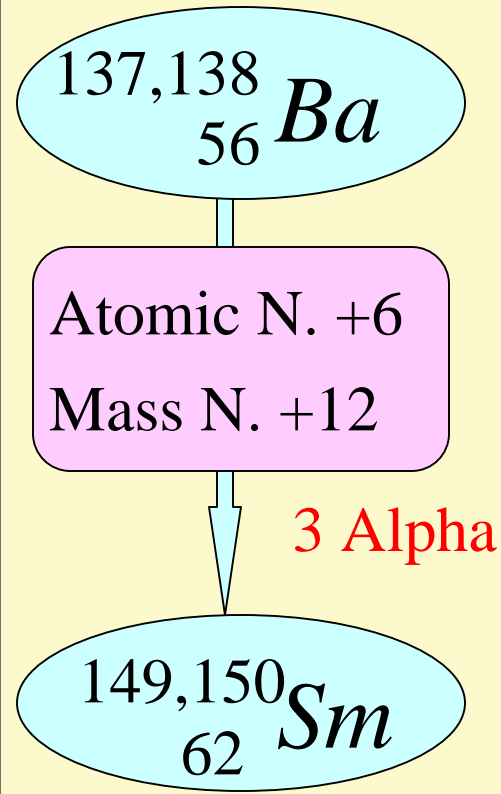


Transmutation of Ba into Sm

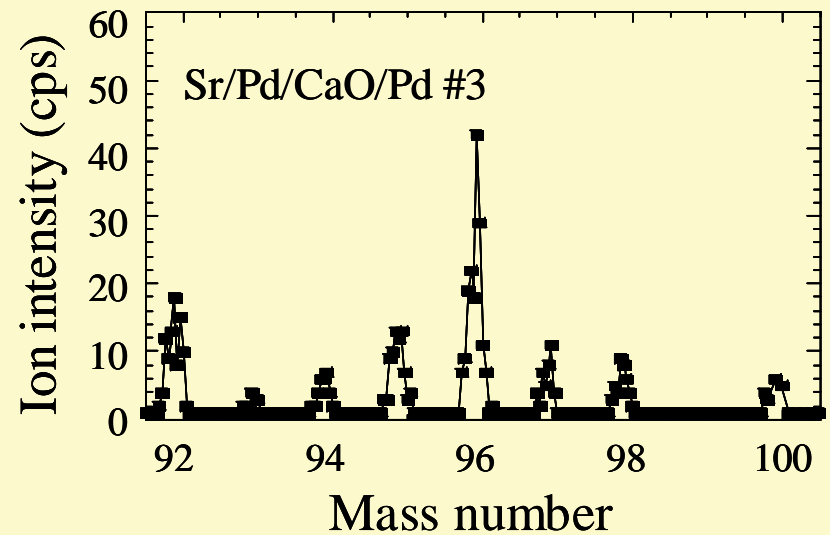
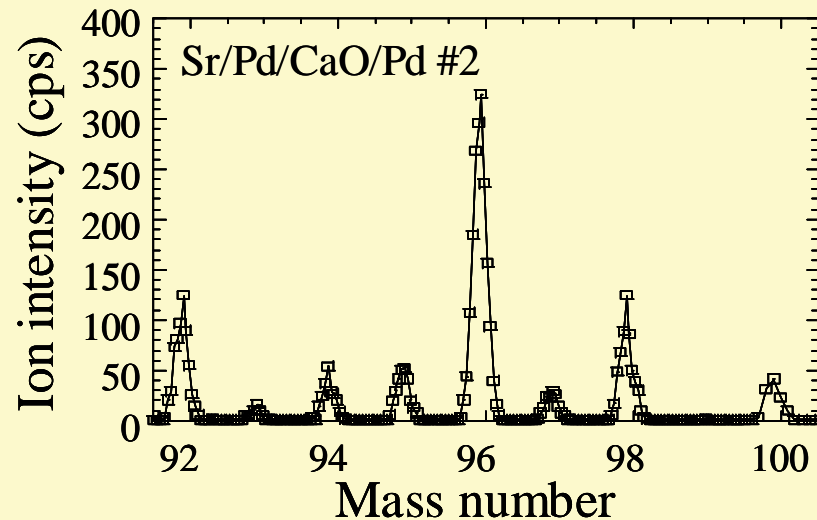
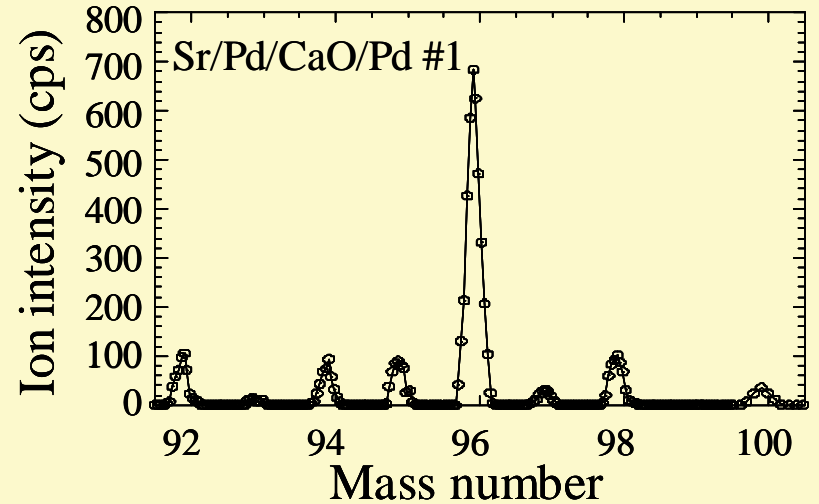
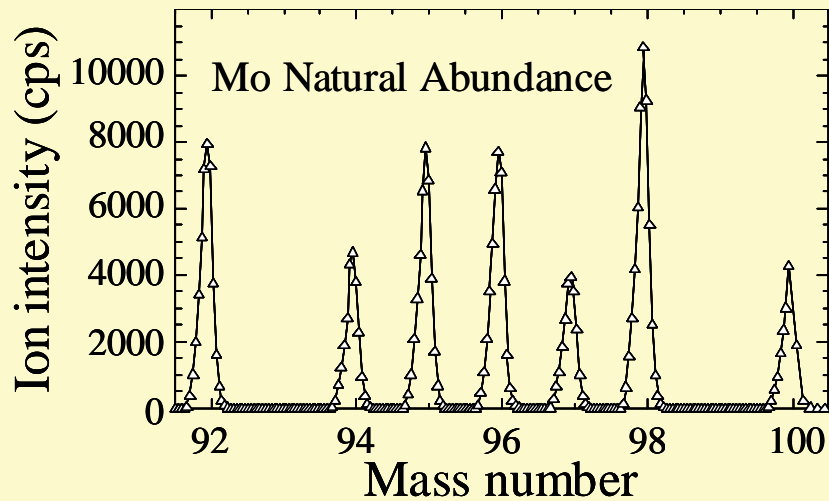
元素の周期表

	IA	IIA	IIIA	IVA	VA	VIA	VIIA	VIIIA	IB	IIB	IIIB	IVB	VB	VIB	VII B	0		
1	H															He		
2	Li	Be							B	C	N	O	F			Ne		
3	Na	Mg							Al	Si	P	S	Cl			Ar		
4	K	Ca	Sc	Ti	V	Cr	Mn	Fe	Co	Ni	Cu	Zn	Ga	Ge	As	Se	Br	Kr
5	Rb	Sr	Y	Zr	Nb	Mo	Tc	Ru	Rh	Pd	Ag	Cd	In	Sn	Sb	Te	I	Xe
6	Cs	Ba	L	Hf	Ta	W	Re	Os	Ir	Pt	Au	Hg	Tl	Pb	Bi	Po	At	Rn
7	Fr	Ra	A															
		L	La	Ce	Pr	Nd	Pm	Sm	Eu	Gd	Tb	Dy	Ho	Er	Tm	Yb	Lu	
		A	Ac	Th	Pa	U	Np	Pu	Am	Cm	Bk	Cf	Es	Fm	Md	No	Lr	

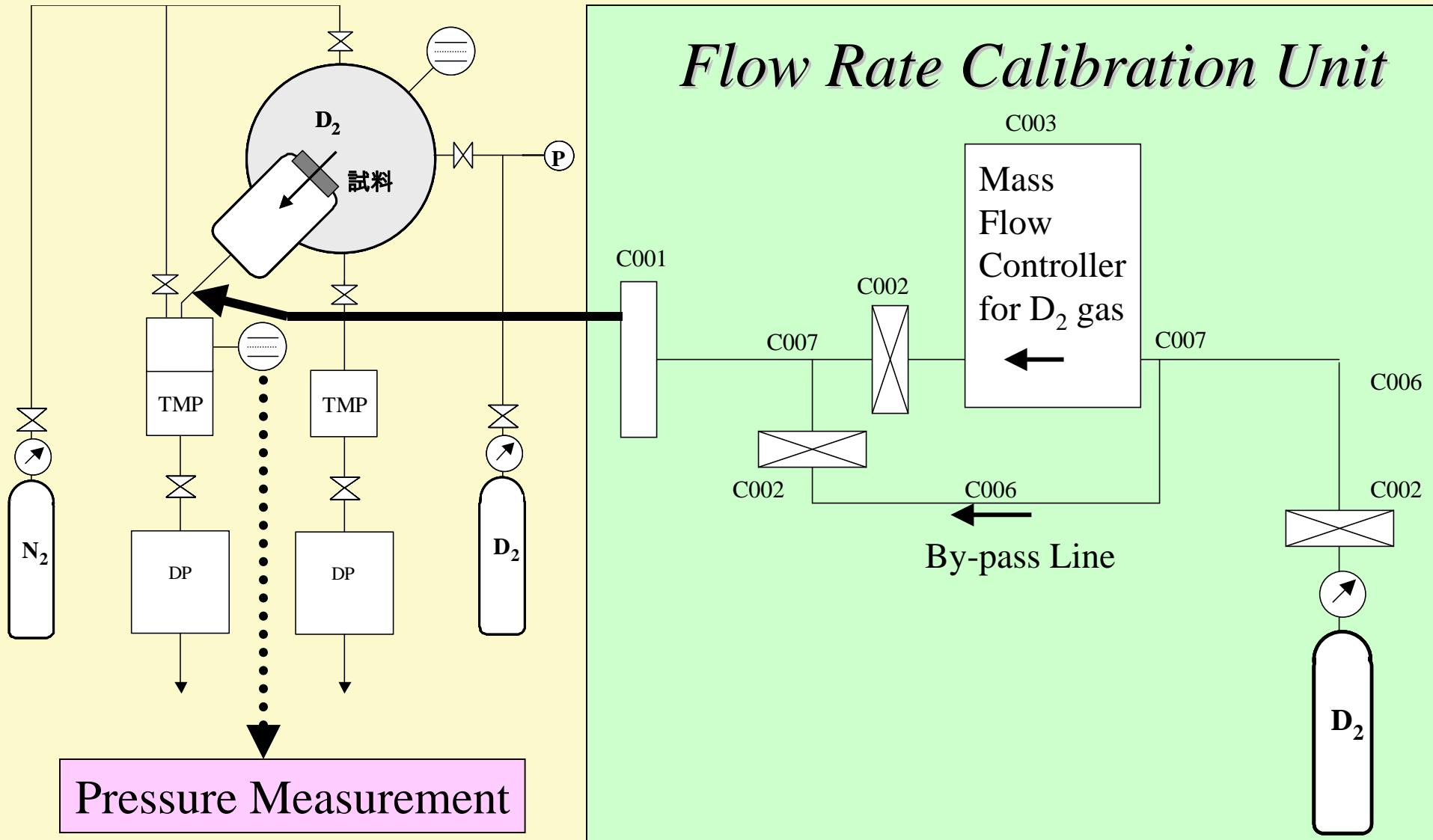
- 典型金属元素
- 半金属元素
- 非金属元素
- 遷移金属元素
- 希ガス



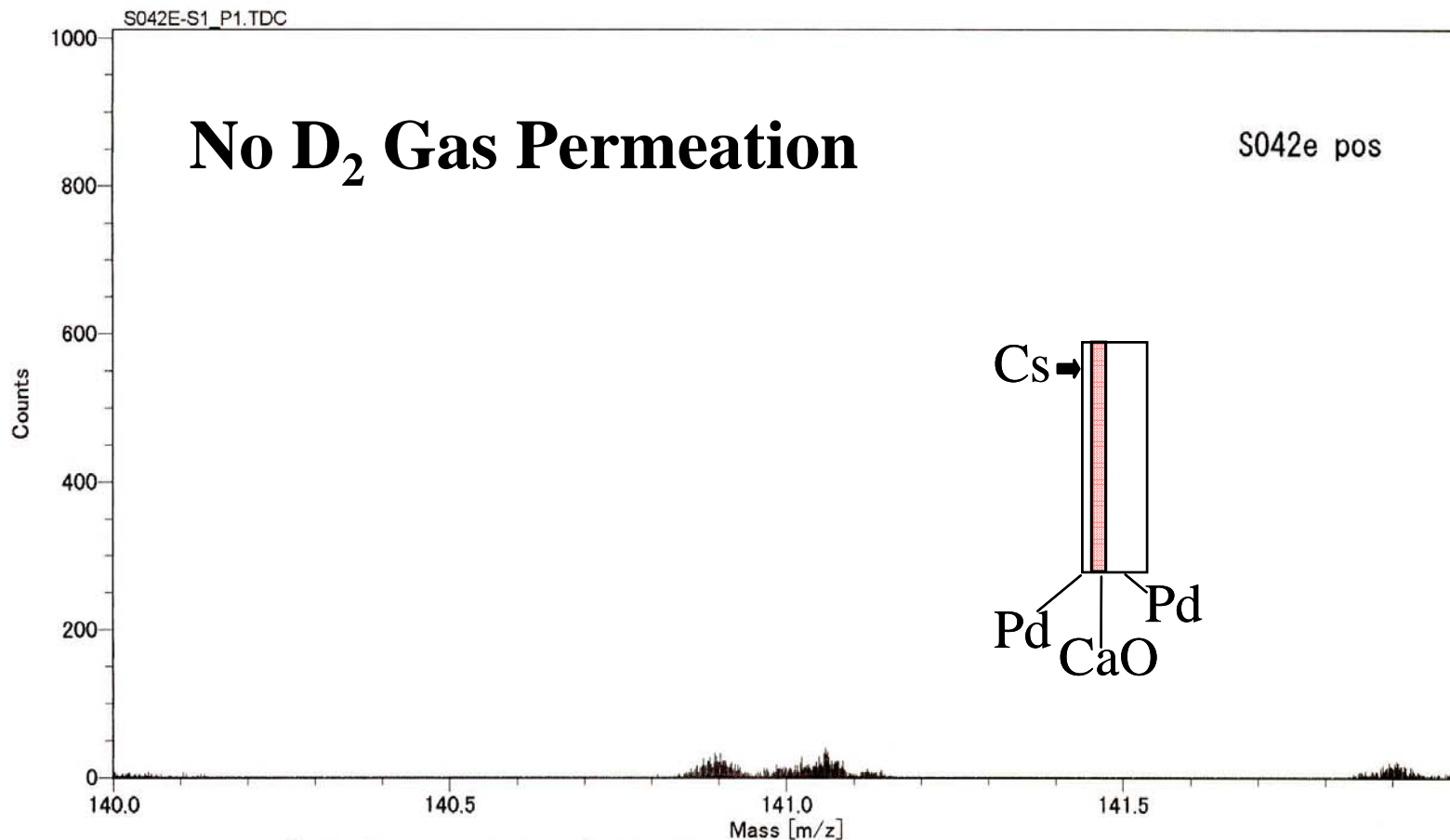
Isotopic Anomaly of the detected Mo



Evaluation of D₂ Gas Flow Rate



Identification of Pr by TOF-SIMS(2)

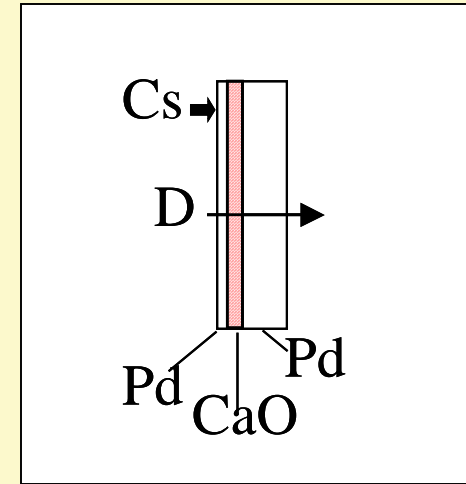
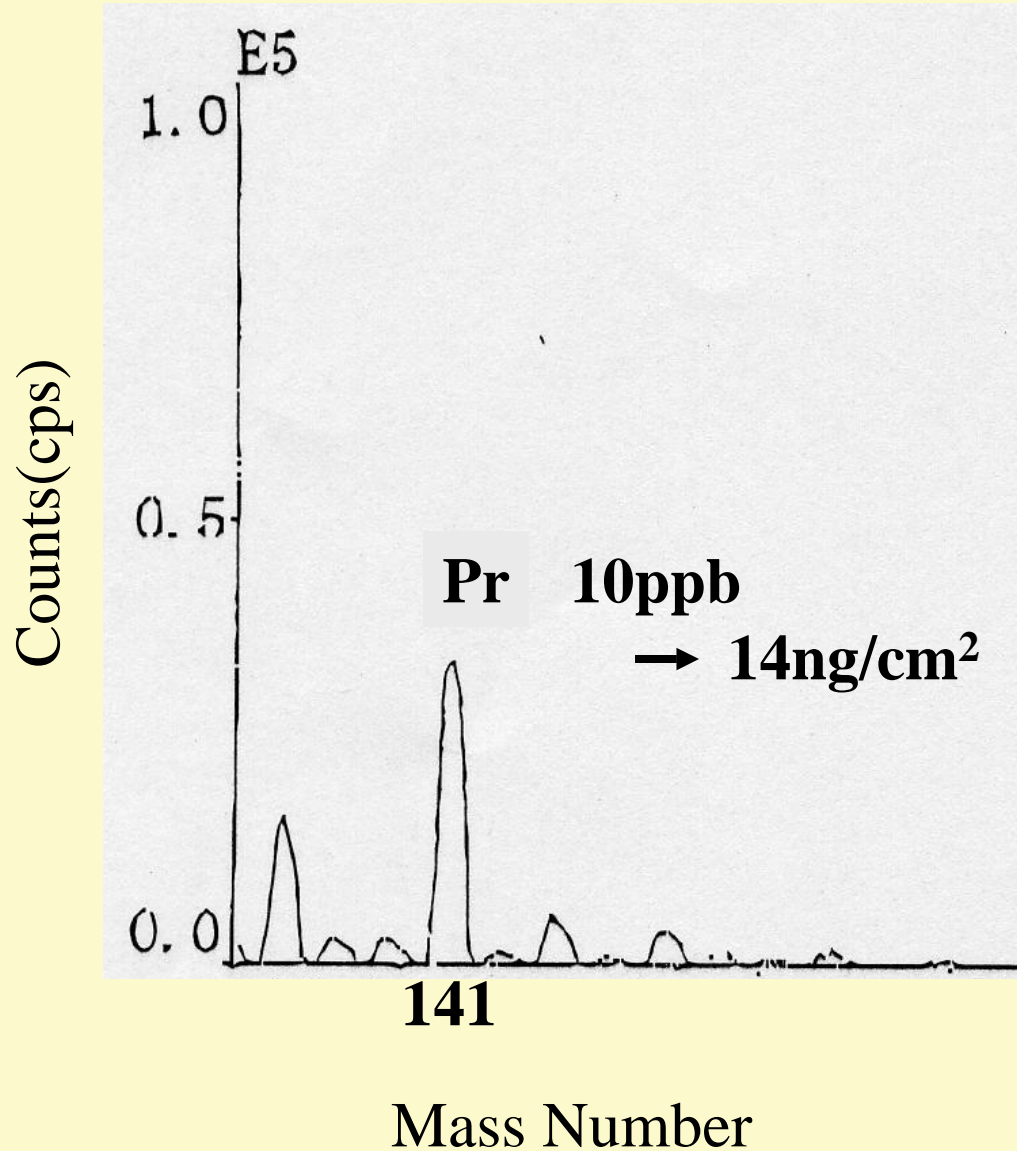


SK67-S1_p1.tdc 3.8 min on 8月 30, 2001 + ions 5320416 cts (100.0 x 100.0 um) using LMIG

S042e-S1_p1.tdc 3.9 min on 8月 30, 2001 + ions 5343585 cts (100.0 x 100.0 um) using LMIG

TOF-SIMS device (TRIFT™ II ;ULVAC-PHI)

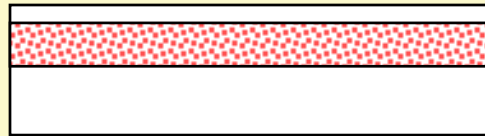
Cs添加Pd多層膜重水素透過後



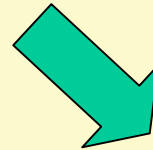
→ Prを検出、定量

Element Addition

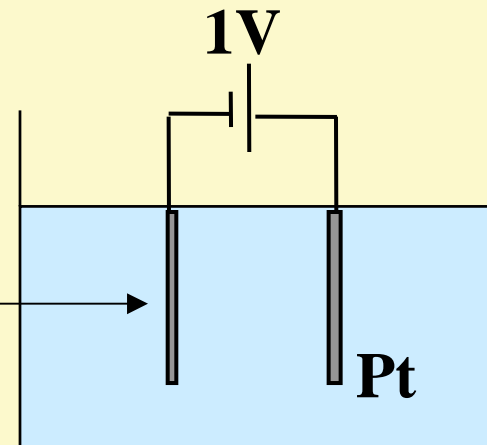
(1: Electrolyte Addition)



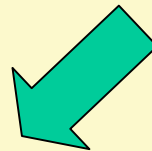
Pd Complex



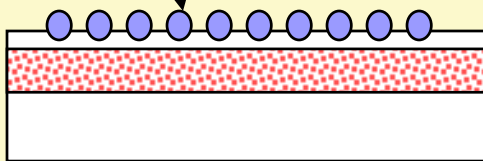
Pd Complex



**1mM CsNO₃/D₂O solution
or 1mM Sr(OD)₂/D₂O solution**

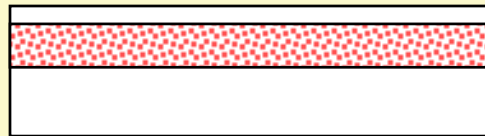


Cs or Sr

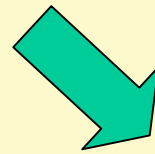


Pd Complex

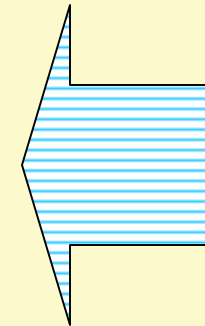
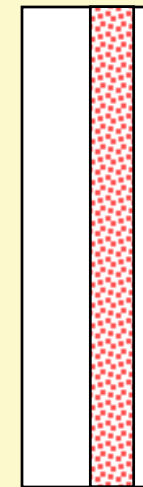
Element Addition (2: Ion Implantation)



Pd Complex



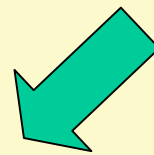
Cs Ion implantation



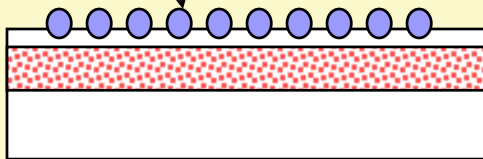
Cs⁺

(18kV, 1.0E15 ions/cm²)

Pd Complex



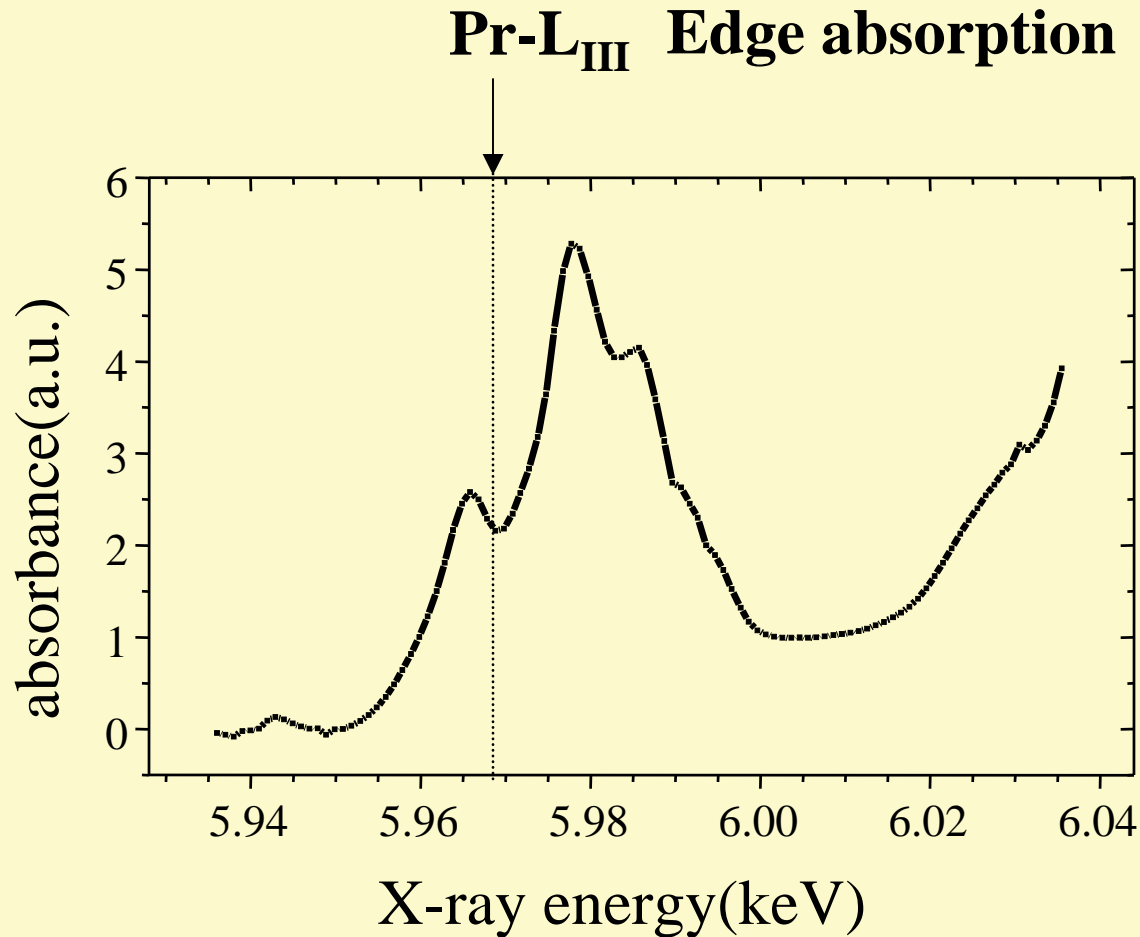
Cs



Pd Complex

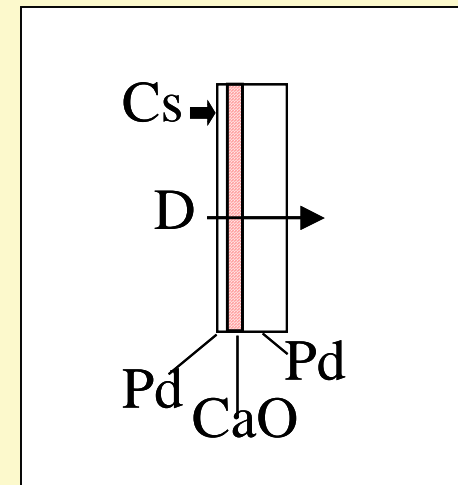
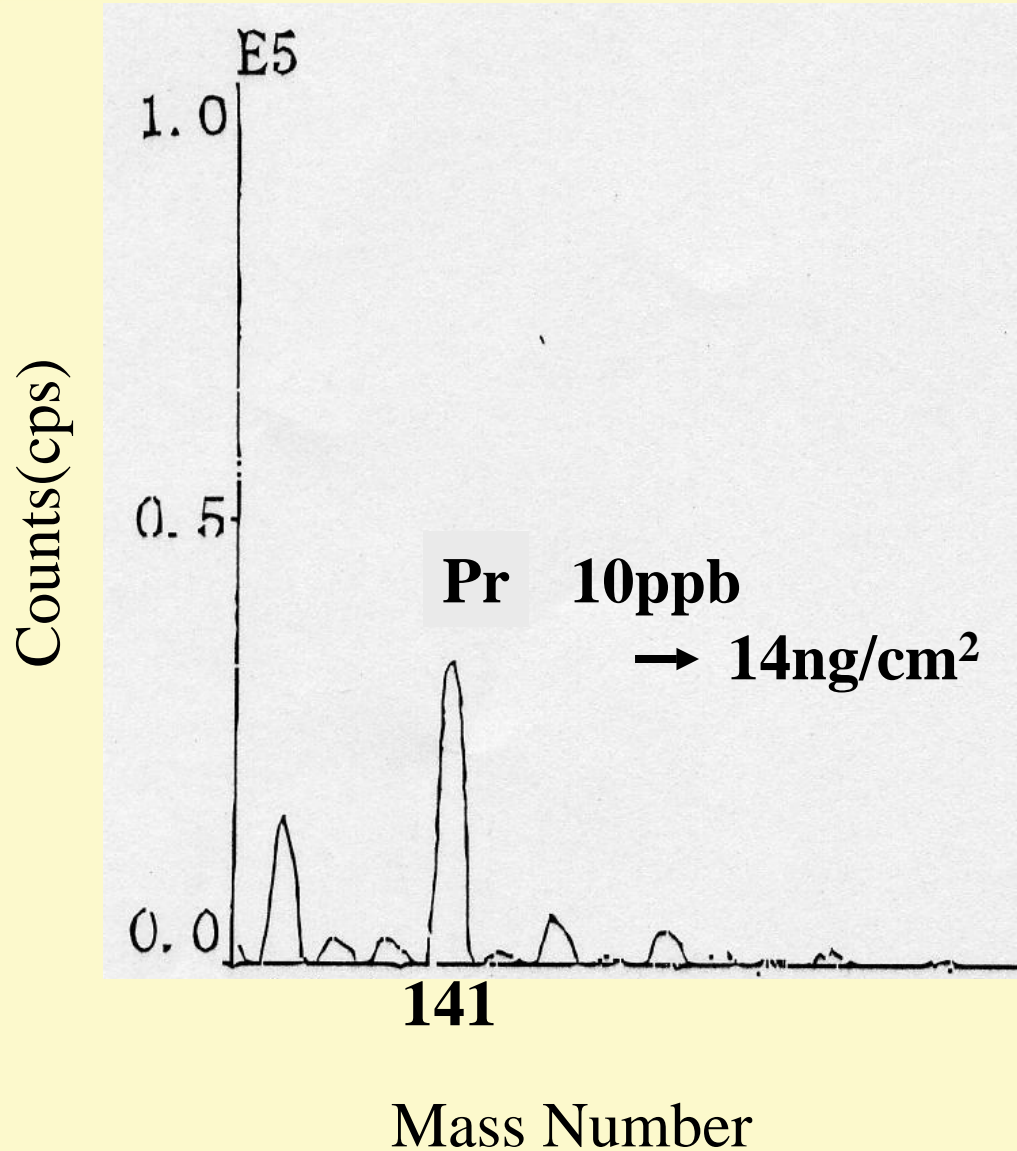
Identification of Pr by XANES

XANES(X-ray Absorption Near Edge Structure)



BL-9A Line, KEK, Tsukuba, Japan

Identification of Pr by ICP-MS



→ Quantitative Analysis

Preparation of the Pd Complex

Washing a Palladium Sample with Acetone



900° C 10H Annealing under Vacuum
Condition ($< 10^7$ Torr)



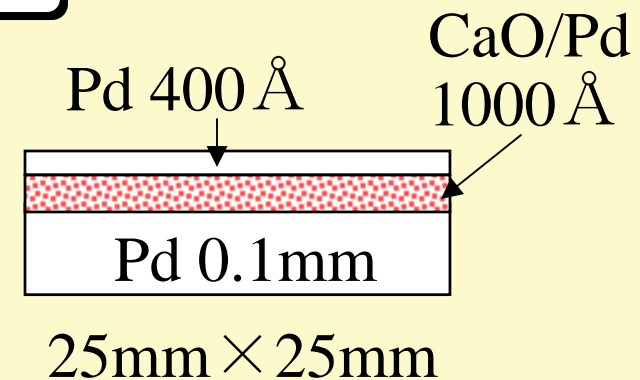
Washing the Sample with Aqua Regia (100sec)



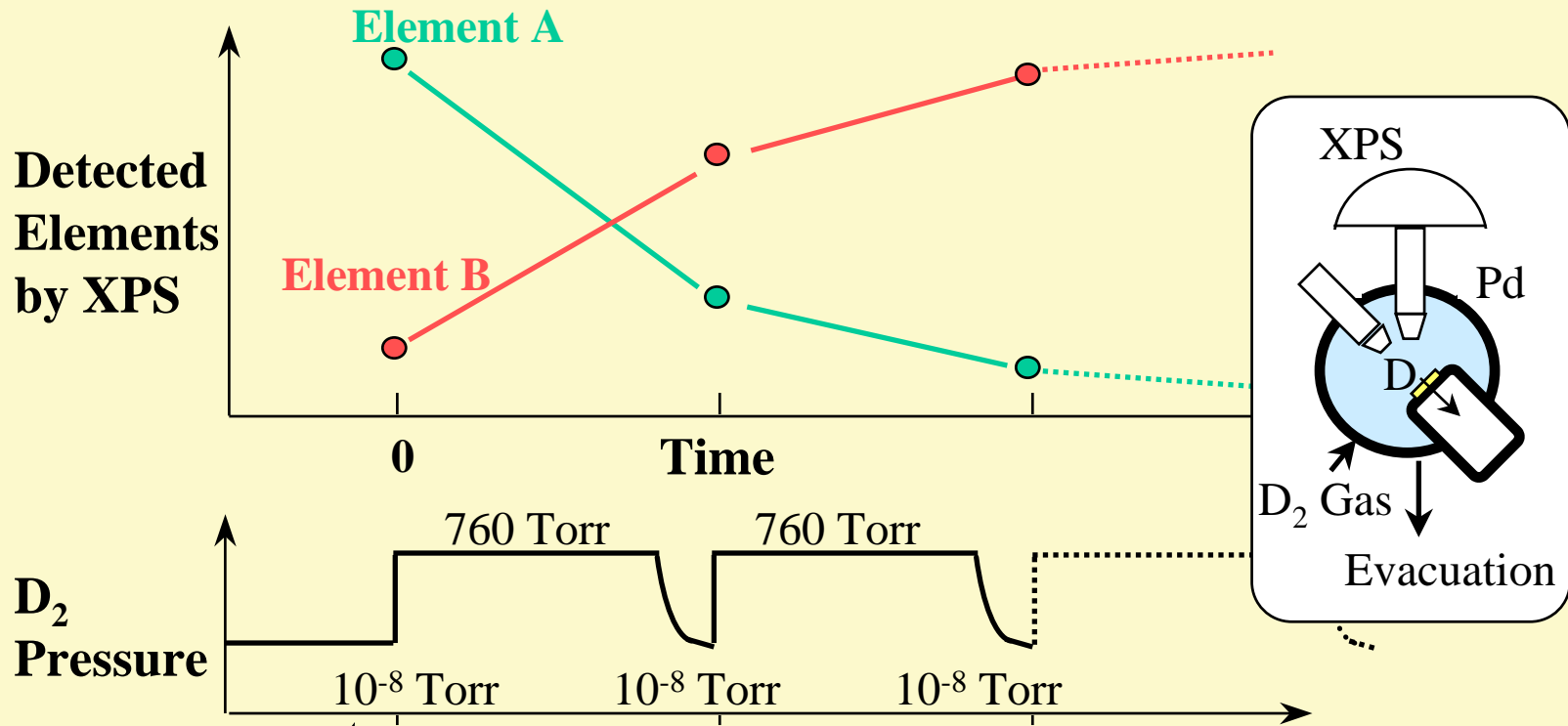
5 times Alternatingly Sputtering of
CaO(20 Å) and Pd(180 Å)



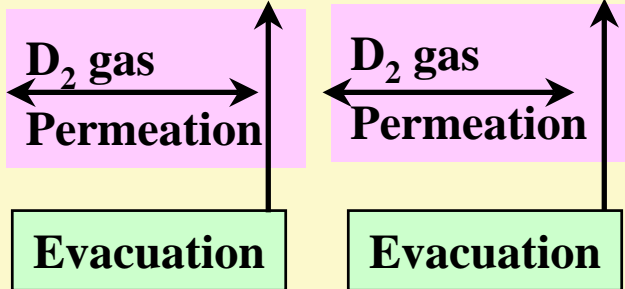
Ion Beam Sputtering of Pd only (400 Å)



Procedure of an Experiment



Sample Preparation
Set the sample
Heat up the sample

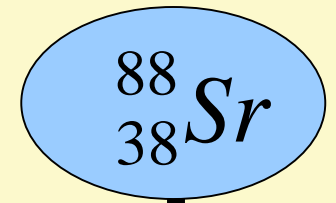


Transmutation of Sr into Mo

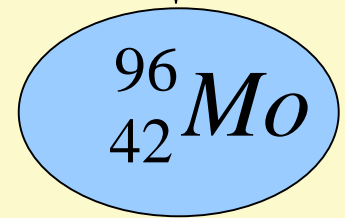
元素の周期表

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2	3 Li	4 Be							5 B	6 C	7 N	8 O	9 F	10 Ne				
3	11 Na	12 Mg							13 Al	14 Si	15 P	16 S	17 Cl	18 Ar				
4	19 K	20 Ca	21 Sc	22 Ti	23 V	24 Cr	25 Mn	26 Fe	27 Co	28 Ni	29 Cu	30 Zn	31 Ga	32 Ge	33 As	34 Se	35 Br	36 Kr
5	37 Rb	38 Sr	39 Y	40 Zr	41 Nb	42 Mo	43 Tc	44 Ru	45 Rh	46 Pd	47 Ag	48 Cd	49 In	50 Sn	51 Sb	52 Te	53 I	54 Xe
6	55 Cs	56 Ba	57 L	72 Hf	73 Ta	74 W	75 Re	76 Os	77 Ir	78 Pt	79 Au	80 Hg	81 Tl	82 Pb	83 Bi	84 Po	85 At	86 Rn
7	87 Fr	88 Ra	89 A															
			57 L	58 La	59 Ce	60 Pr	61 Nd	62 Pm	63 Sm	64 Eu	65 Gd	66 Tb	67 Dy	68 Ho	69 Er	70 Tm	71 Yb	Lu
			89 A	90 Ac	91 Th	92 Pa	93 U	94 Np	95 Pu	96 Am	97 Cm	98 Bk	99 Cf	100 Es	101 Fm	102 Md	103 No	Lr

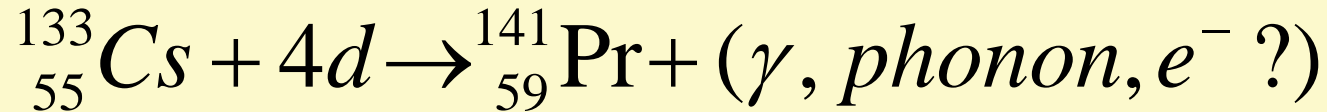
- 典型金属元素
- 半金属元素
- 非金属元素
- 遷移金属元素
- 希ガス



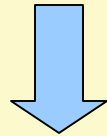
Atomic N. +4
Mass N. +8



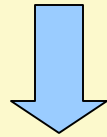
Excess Energy and Q-value



$$Q \approx 50.5 \text{ MeV}$$



$$EXH = 800 \text{ J}$$



$$P_{EXH} \approx 2.2 \text{ mW}$$

Experimental results

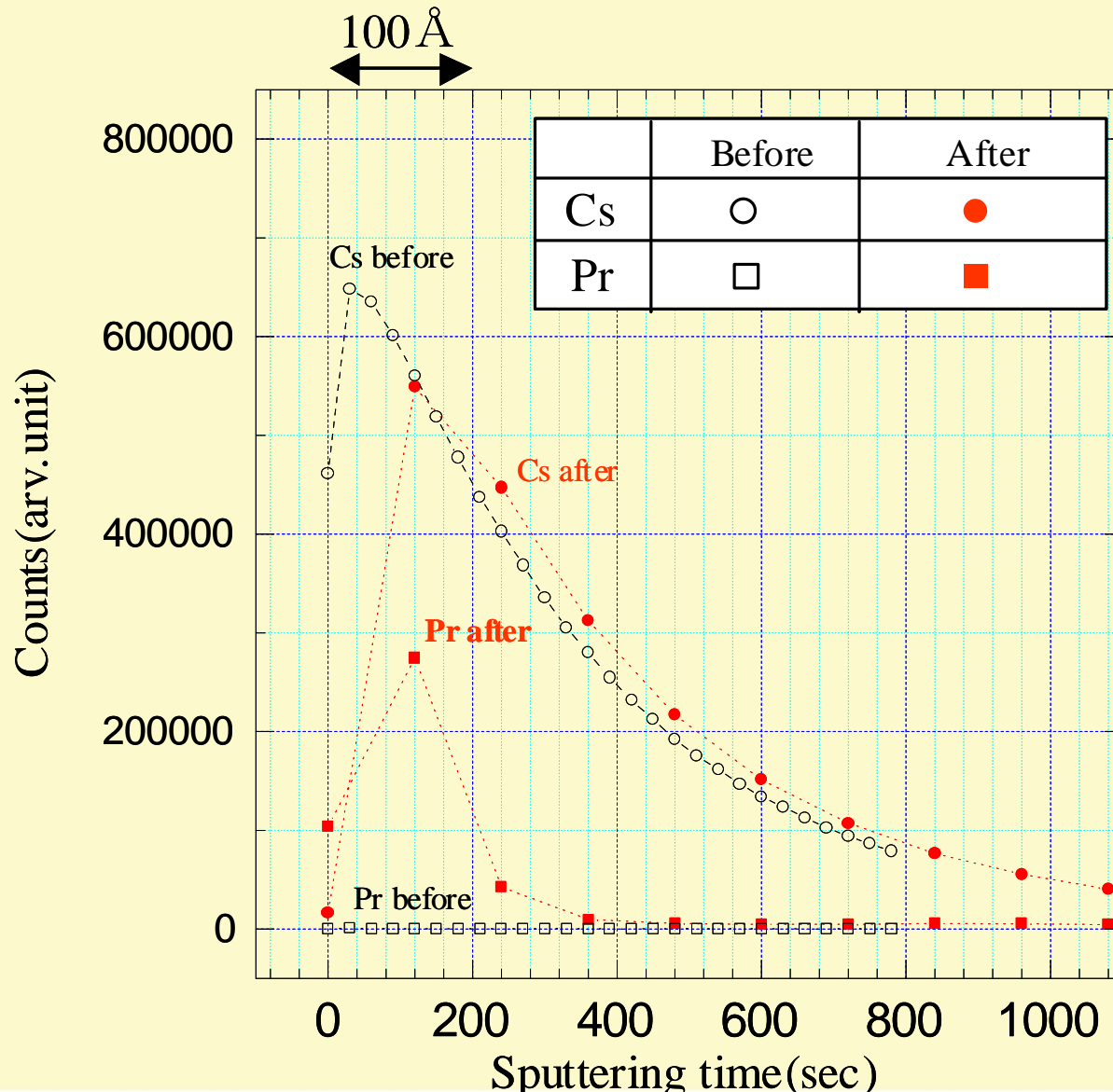
$$\text{Pr} \approx 10^{14} \text{ atoms}$$

$$\text{reaction time} \approx 100 \text{ h}$$

→ Undetectable in our experimental setup

Depth Profile of Cs and Pr : Ion Implantation

MITSUBISHI HEAVY INDUSTRIES, LTD.
ADVANCED TECHNOLOGY RESEARCH CENTER

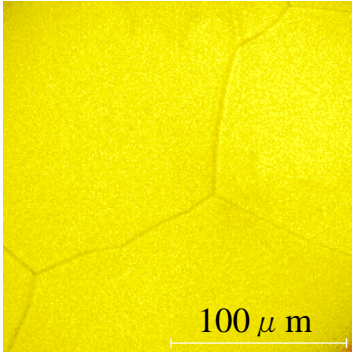
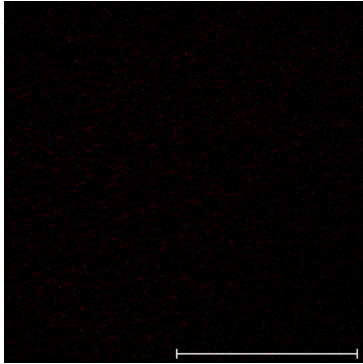
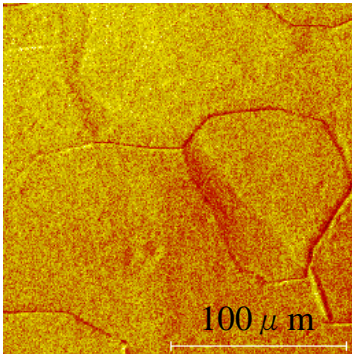
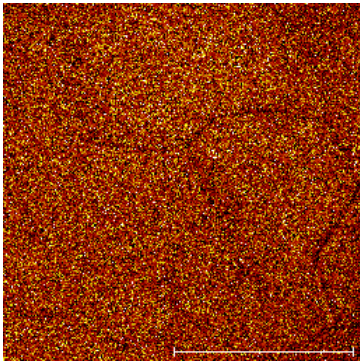


Surface Distribution of Cs and Pr : Ion Implantation

MITSUBISHI HEAVY INDUSTRIES, LTD.
ADVANCED TECHNOLOGY RESEARCH CENTER

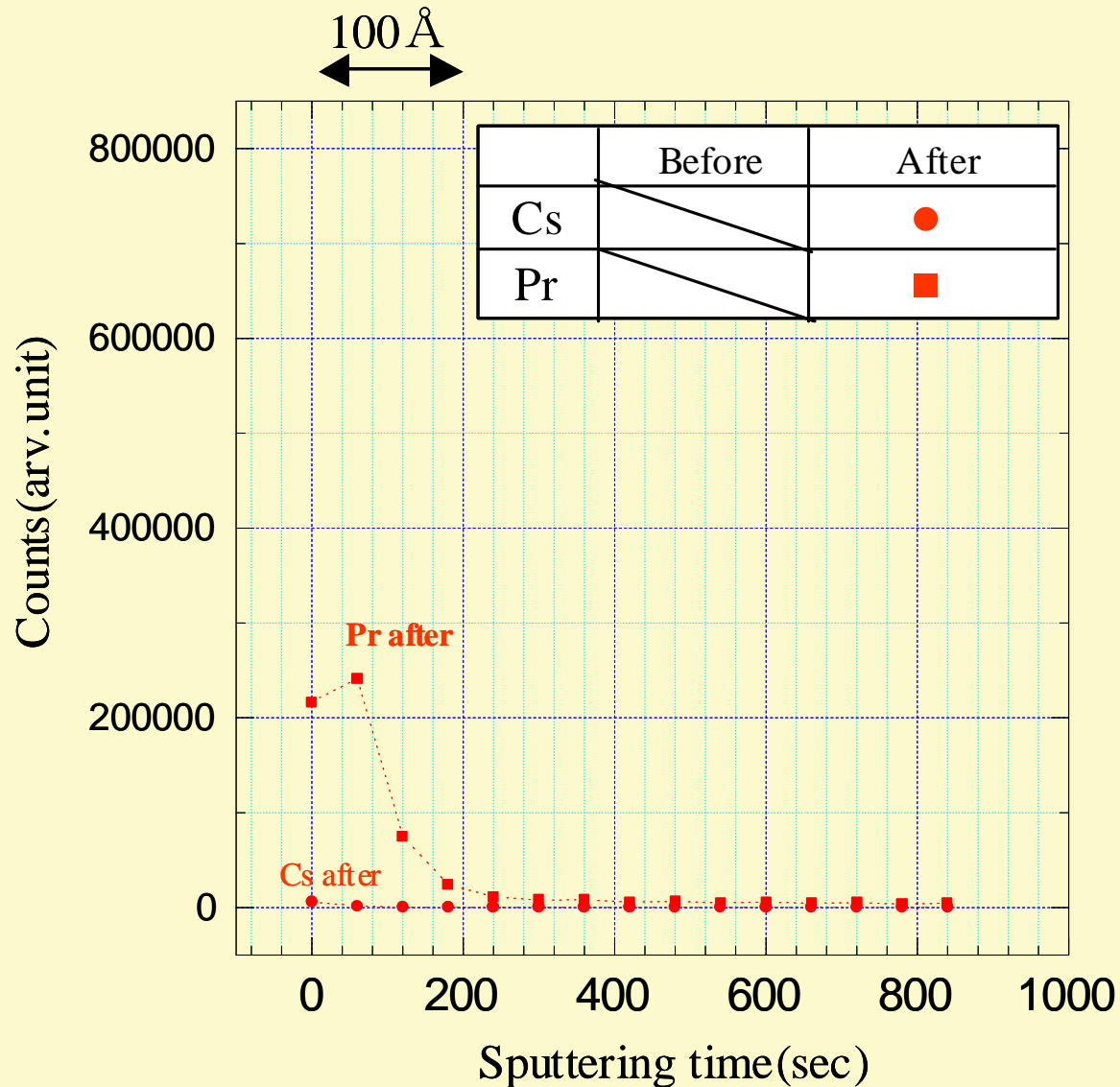
Sample: Cs⁺ Ion Implantation

Analysis: ToF-SIMS (ULVAC fai)

	Cs	Pr
before		
after		

Depth Profile of Cs and Pr : Electrolyte Addition

MITSUBISHI HEAVY INDUSTRIES, LTD.
ADVANCED TECHNOLOGY RESEARCH CENTER

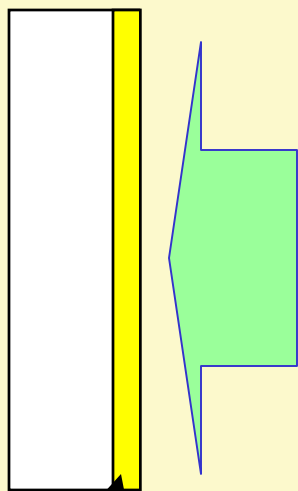


Ultra Low Energy Beam Model

D Permeation(D Flux)



Ultra low D beam



D flux; ϕ

Given Cs; N_{Cs}

$$R = \sigma \cdot N_{Cs} \cdot \phi$$

R : reaction rate(event/cm³/sec)

σ : cross section(cm²) N_{Cs} : Number of Cs (1/cm³)

ϕ : Deuteron beam flux(1/cm²/sec)

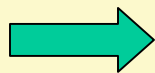
$$\eta = \int_t (R / N_{Cs}) dt = \int (\sigma \cdot \phi) dt = \sigma \int_t \phi dt$$

$$\int_t \phi dt \approx f \cdot FL \cdot T_{\text{exp}} / S$$

FL : Flow rate(sccm) T_{exp} : Reaction Time(sec)

S : Permeation surface area(cm²)

$$\therefore \eta \propto FL$$



Agree with the experimental results

Rough Estimation of the Cross Section

$$\begin{aligned}\eta &= \sigma \cdot f \cdot FL \cdot T_{\text{exp}} / S \\ &= \sigma \cdot \frac{2 \times 6 \times 10^{23}}{22.4 \times 10^3 \times 60} \cdot FL \cdot 100 \times 3600 / 1.0 \\ &= \sigma [cm^2] \cdot FL [sccm] \cdot 3 \times 10^{23} [1/cm^2 / sccm]\end{aligned}$$

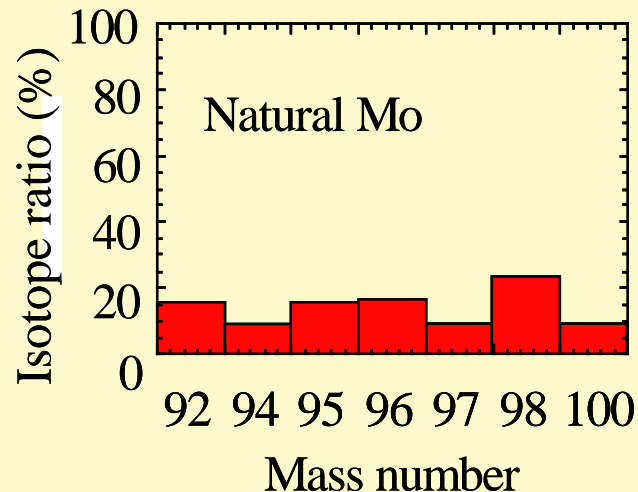
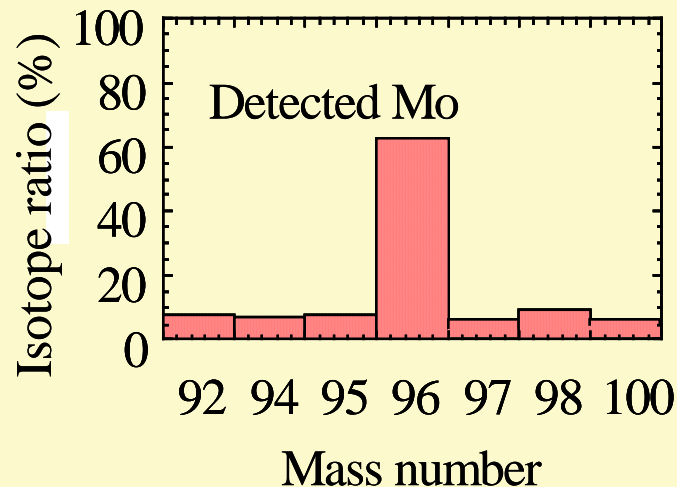
Experimental results $\rightarrow 0.3 = \sigma \cdot 3 \times 10^{23}$

$$\therefore \sigma \approx 1 \times 10^{-24} [cm^2] = 1 [barn]$$

cf. $\sigma_c = 27.2 \text{ barn} : {}^{133}\text{Cs}$ for thermal neutron

Separation of the Products and Contaminants(2)

2. Anomalous Isotopic Composition: Mo



Detection of Pr and Mo cannot be explain by contamination.



Pr and Mo are the products of nuclear transmutation reactions.

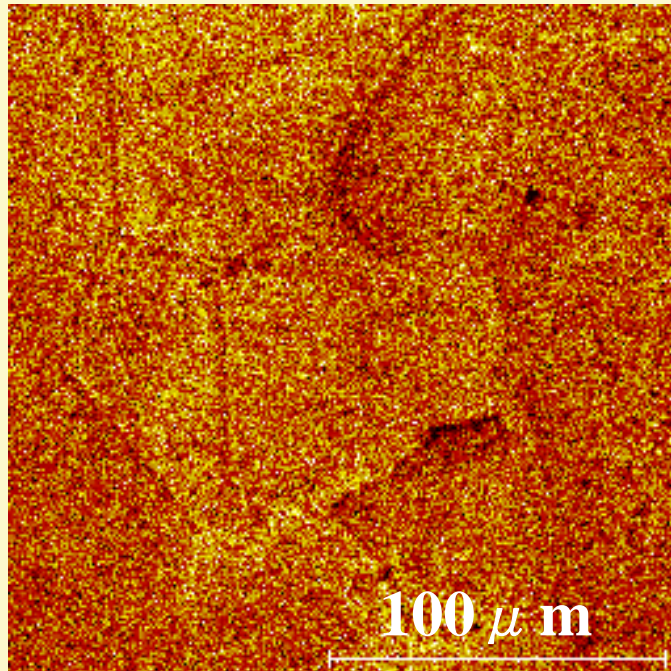
Surface Distribution of Cs and Pr : Electrolyte Addition

MITSUBISHI HEAVY INDUSTRIES, LTD.
ADVANCED TECHNOLOGY RESEARCH CENTER

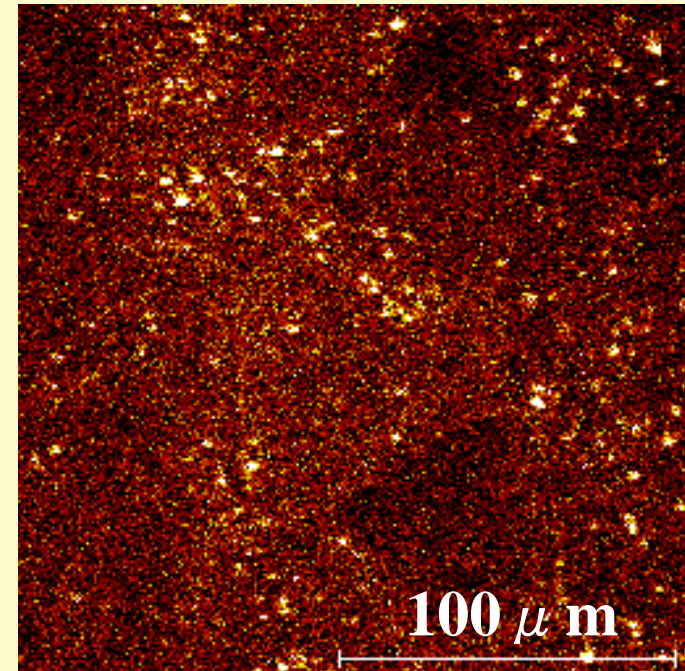
Sample: Cs is added using electrochemical method

Analysis: Tof-SIMS (ULVAC fai)

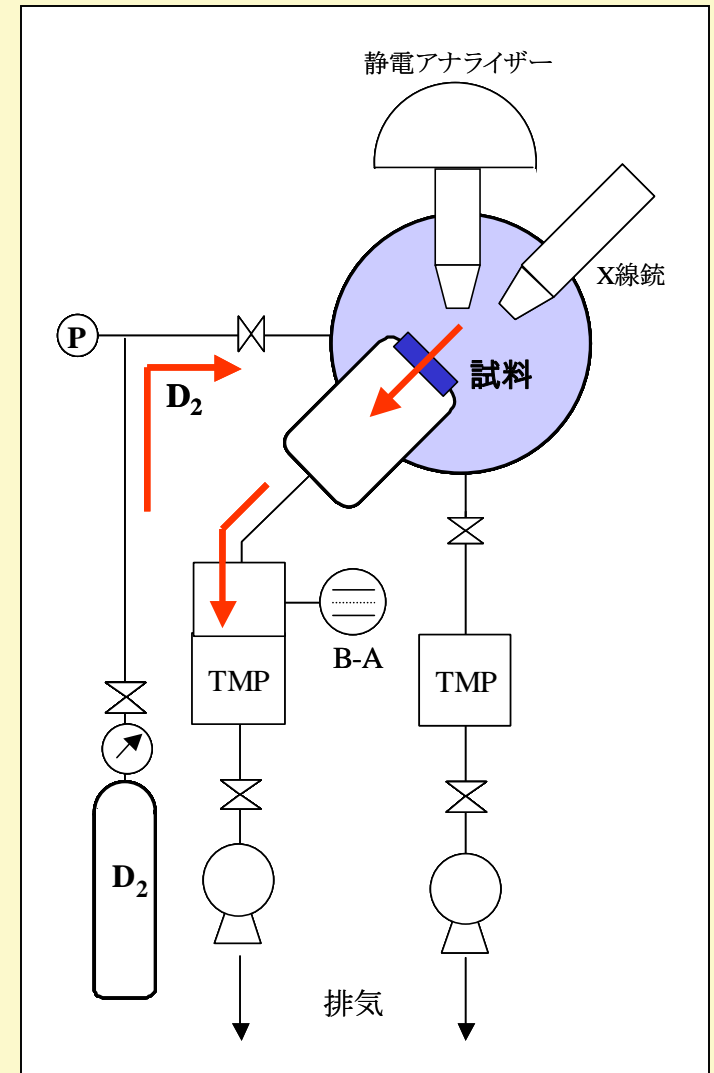
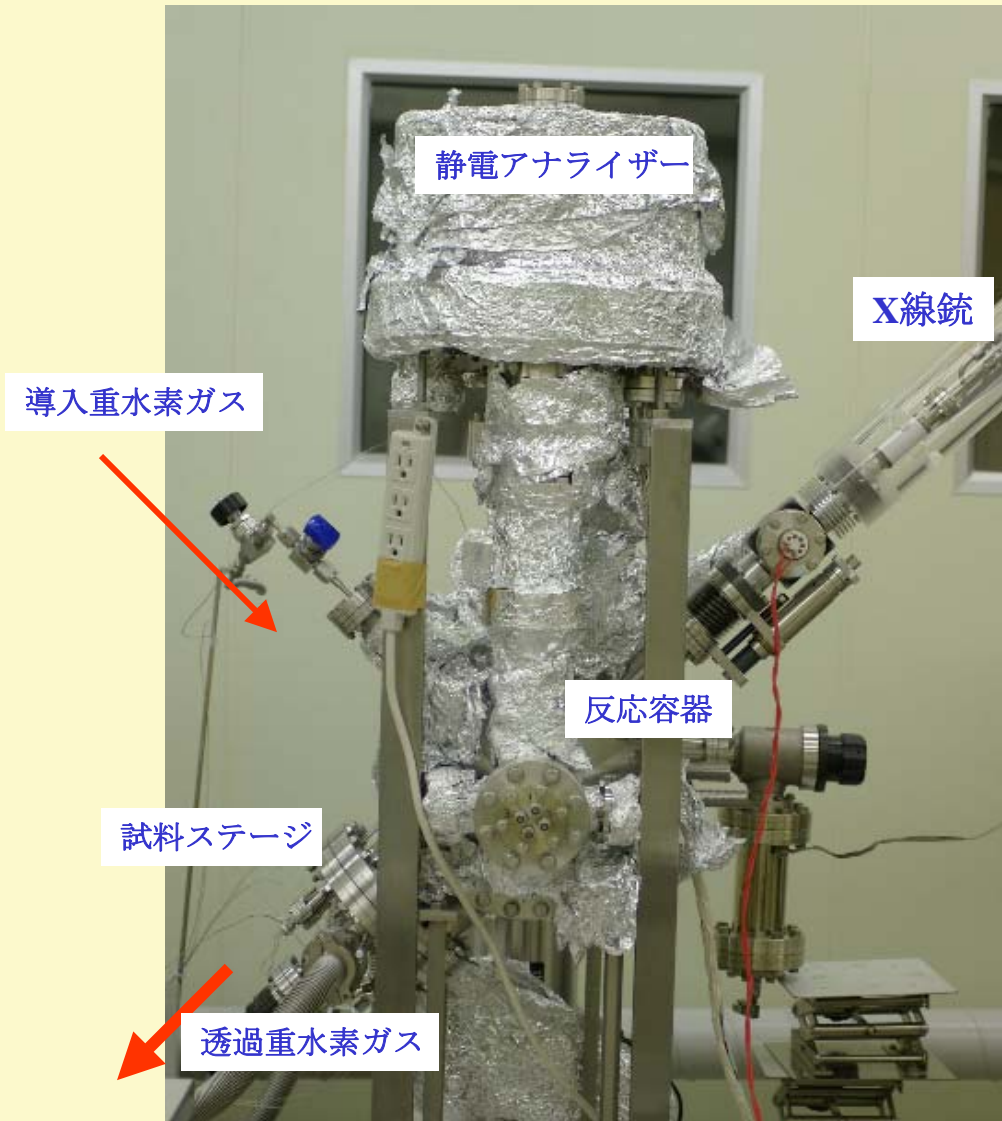
Cs



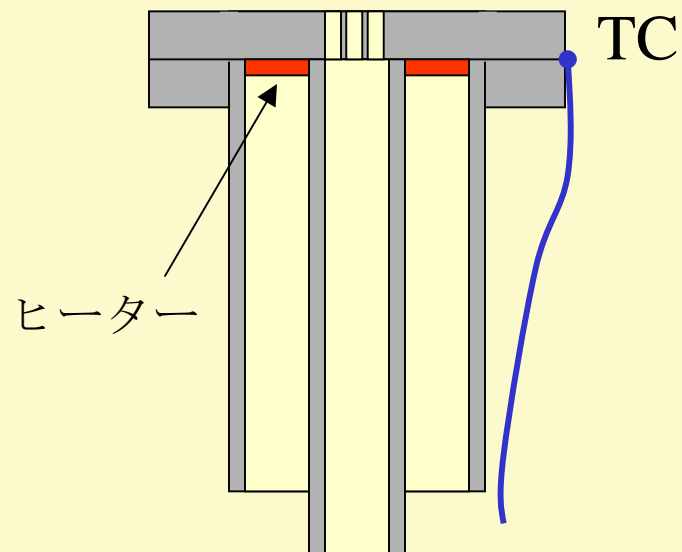
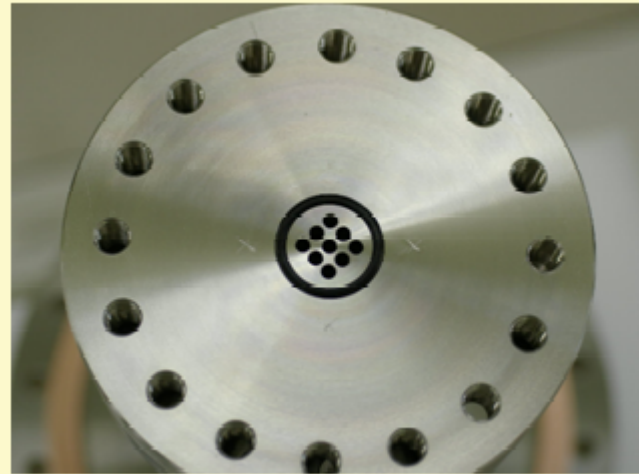
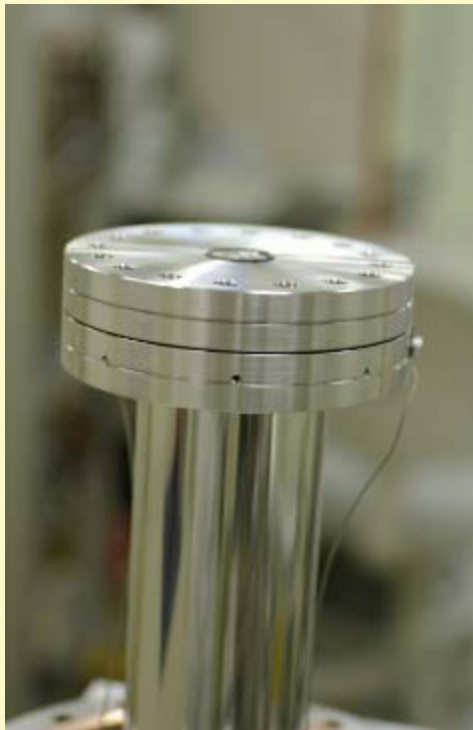
Pr



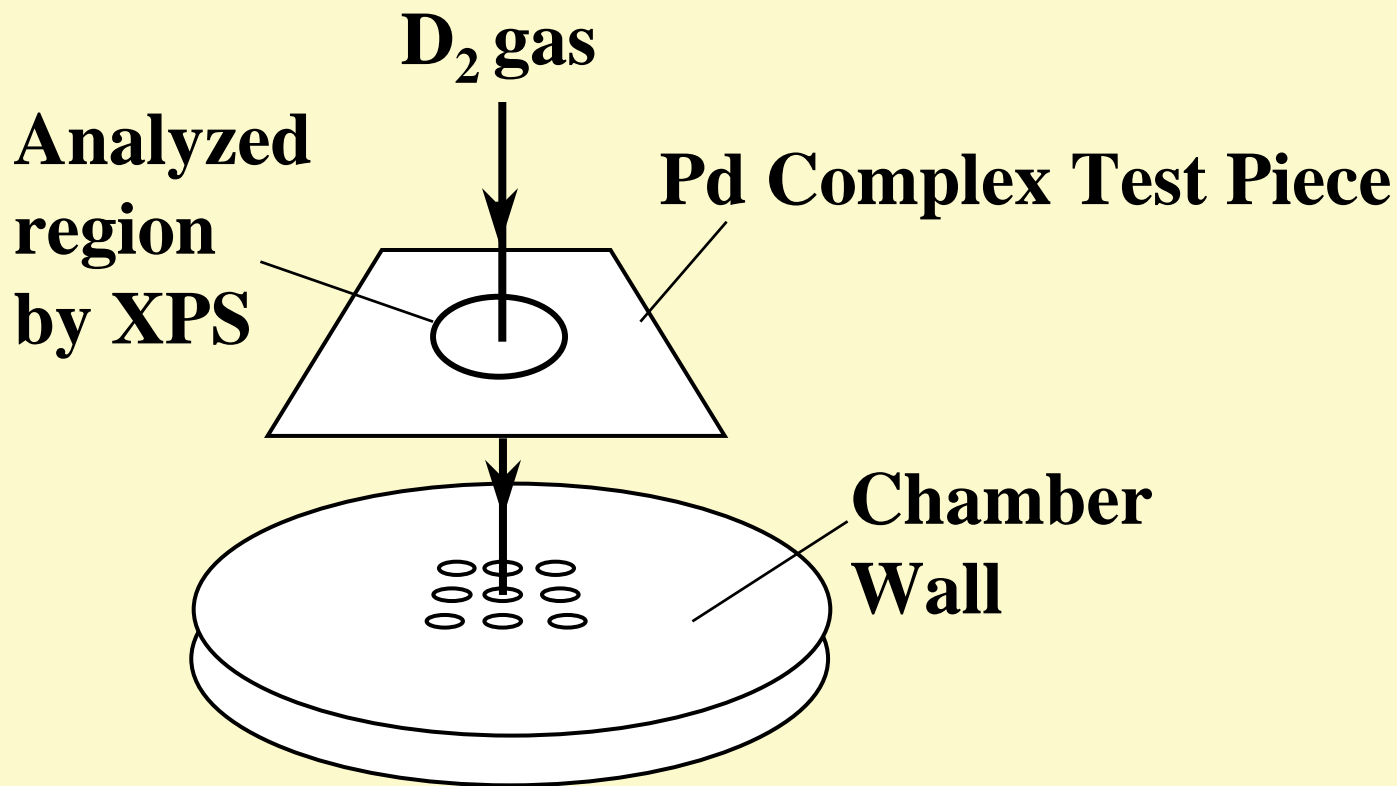
実験装置概観



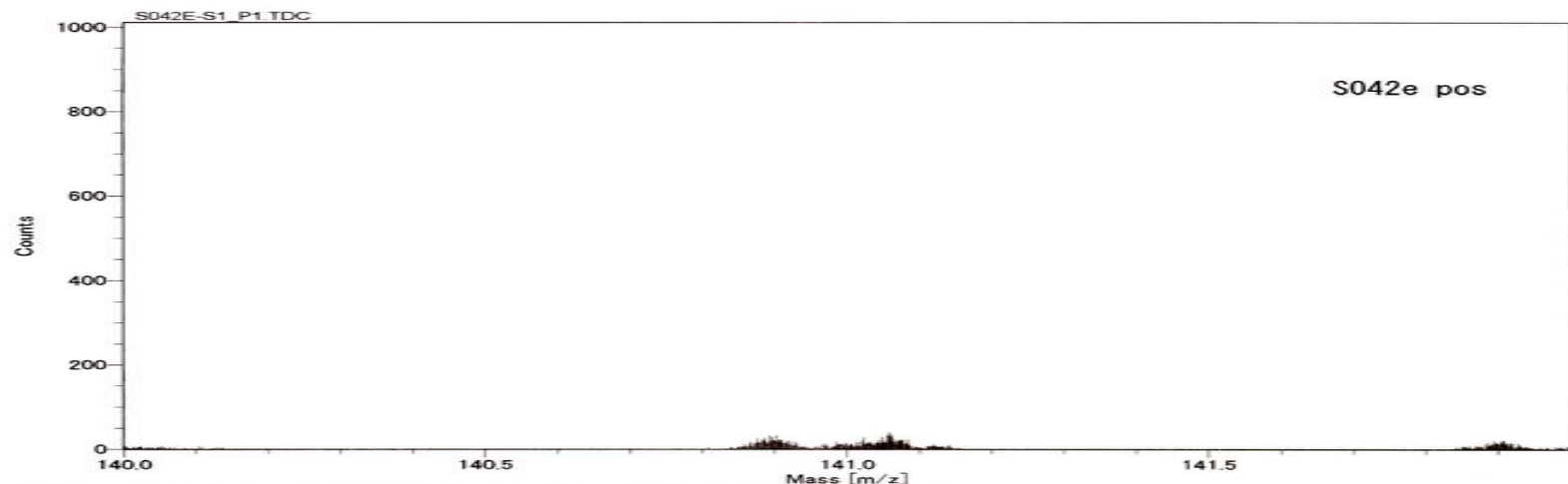
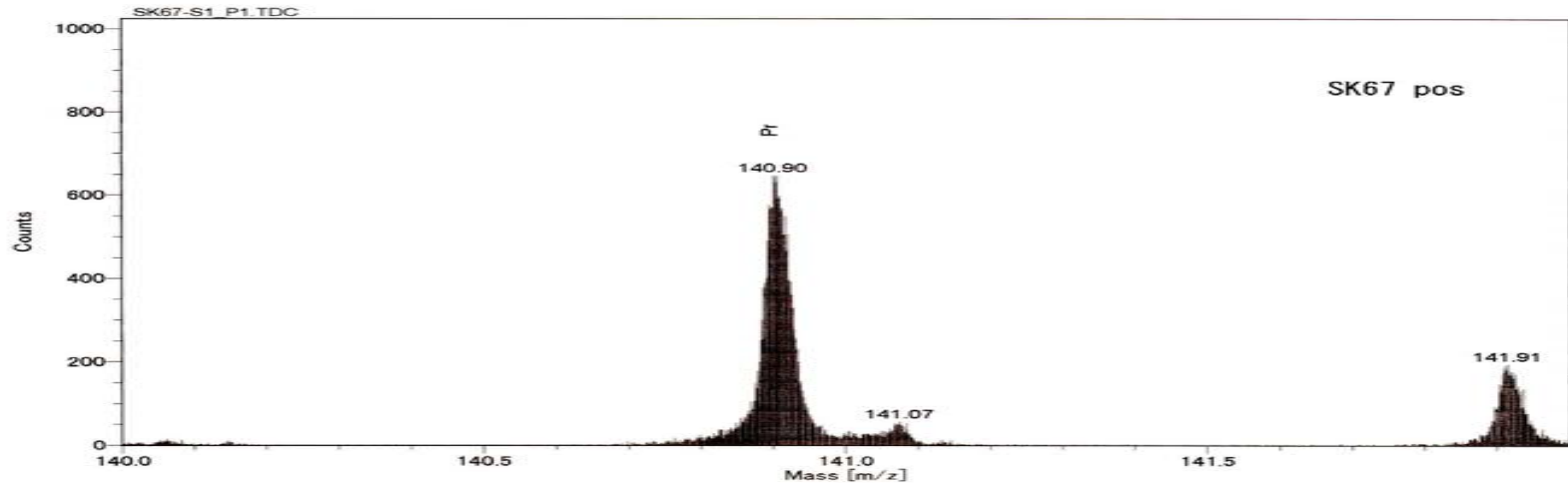
試料ステージ概観



重水素ガスの透過経路



Identification of Pr by TOF-SIMS(2)

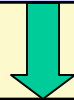


SK67-S1_p1.tdc 3.8 min on 8月 30, 2001 + ions 5320416 cts (100.0 x 100.0 um) using LMIG

S042e-S1_p1.tdc 3.9 min on 8月 30, 2001 + ions 5343585 cts (100.0 x 100.0 um) using LMIG

Quantitative Analysis of Pr by ICP-MS

Step1 : Solve the surface of the Pd Complex by nitric acid
(The nitric acid is Ultra high purity; impurity Ni,Pb~50ppt)



Step2 : Quantitative Analysis of the solution by ICP-MS

ICP-MS(Inductively Coupled Plasma Mass Spectrometry)

High Sensitivity: Detection Limit ~ Pr 0.1ng

Necessary to exclude Molecular Ions

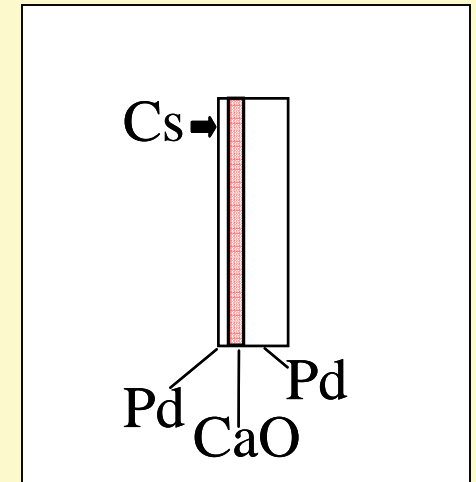
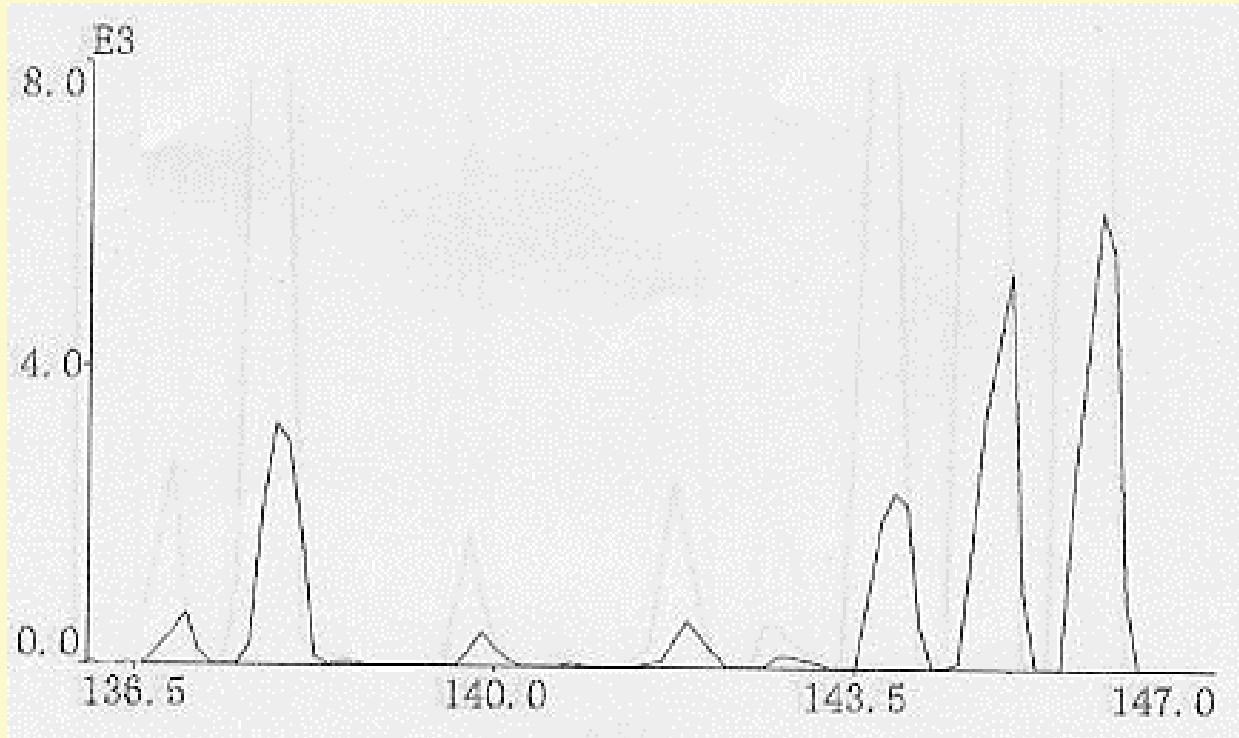
Device : SEIKO Instruments: SPQ9000

Examination of Molecular Ions

Pd	Pd(NO)	PdO ₂
102(1%)	132	134
104 (11%)	134	136
105 (22%)	135	137
106 (27%)	136	138
108 (26%)	138	140
110 (12%)	140	142

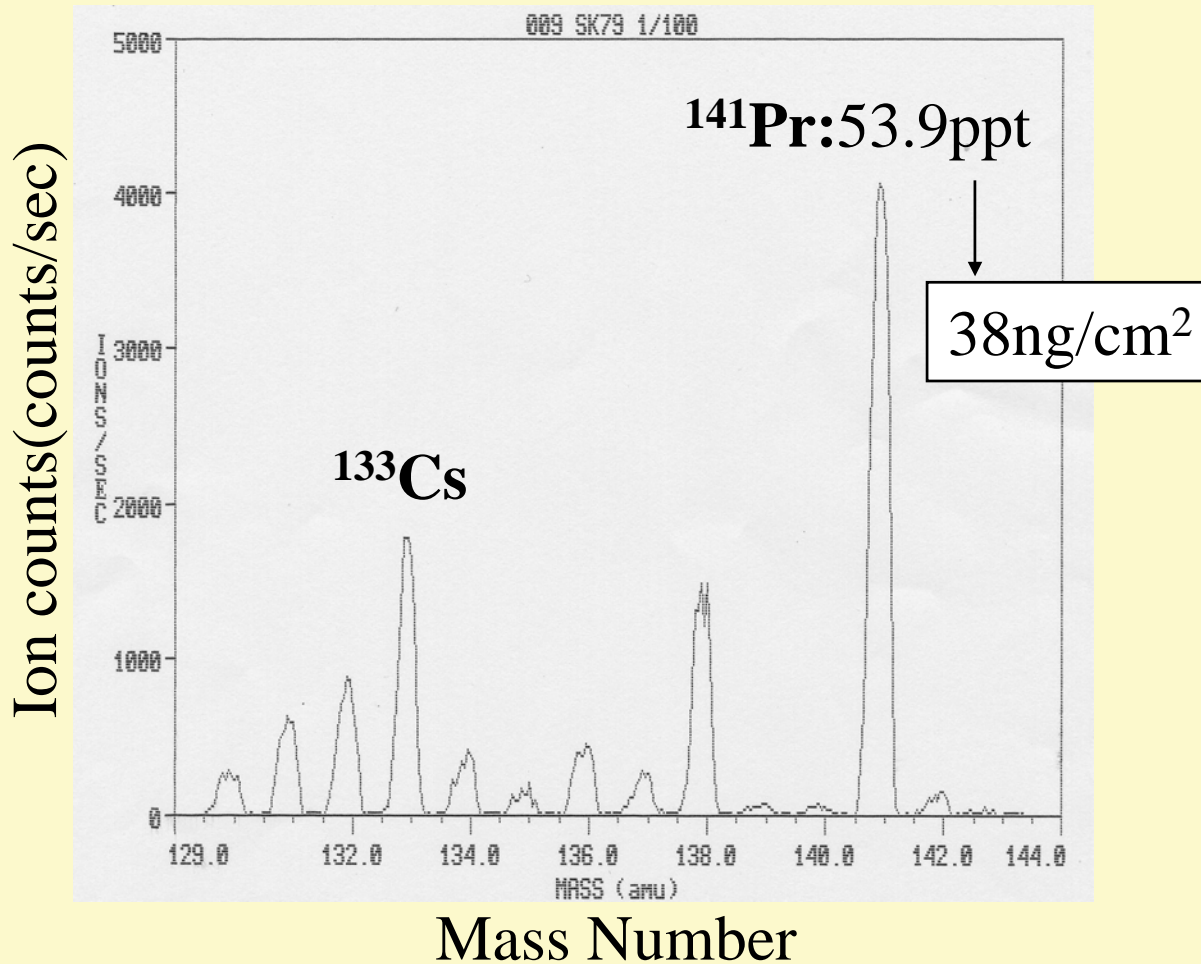
No molecular ions interfering Mass 141(Pr) in this system

No D₂ Gas Permeation

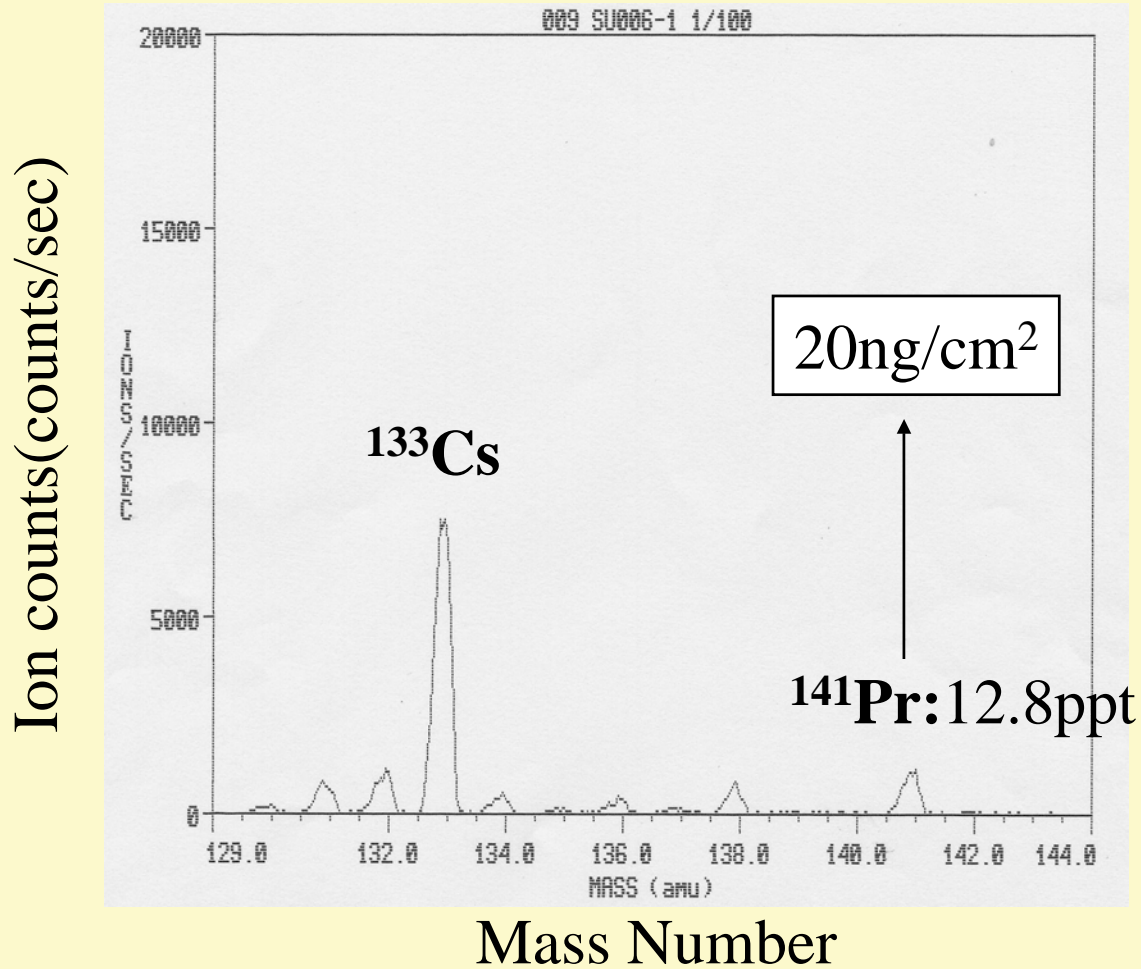


→ Prは検出されず。

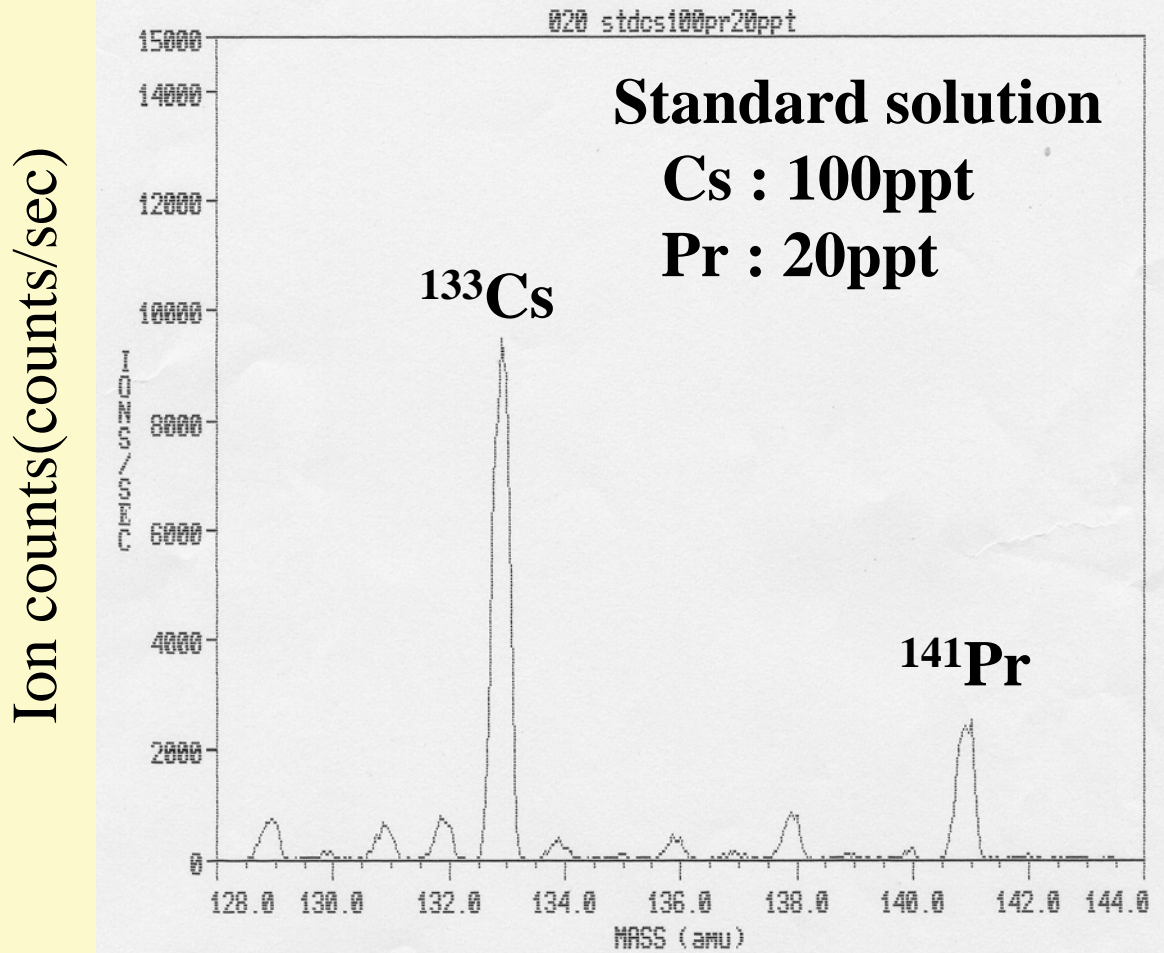
F.G.Data(1)



F.G.Data(2)

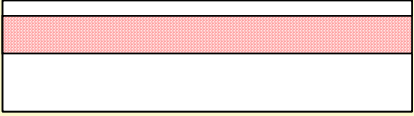
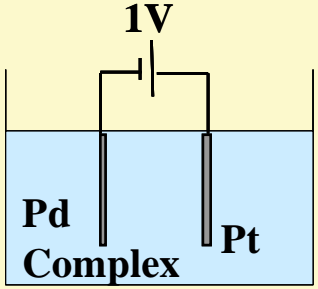
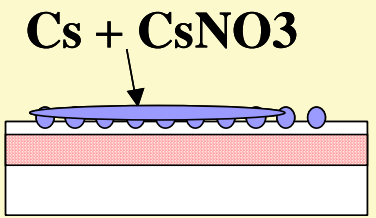
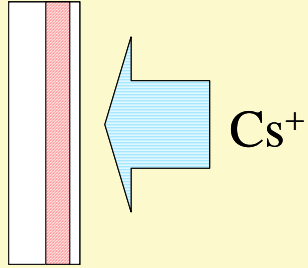
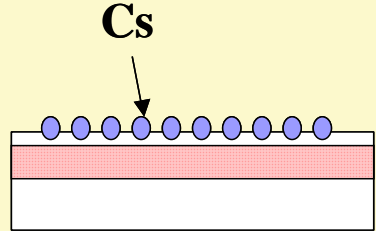
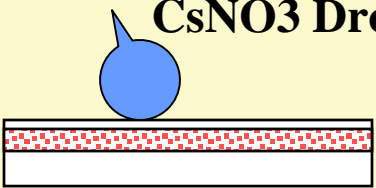
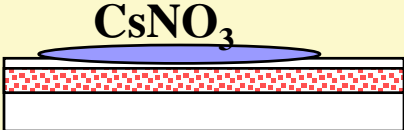


Analysis of the Standard Solution

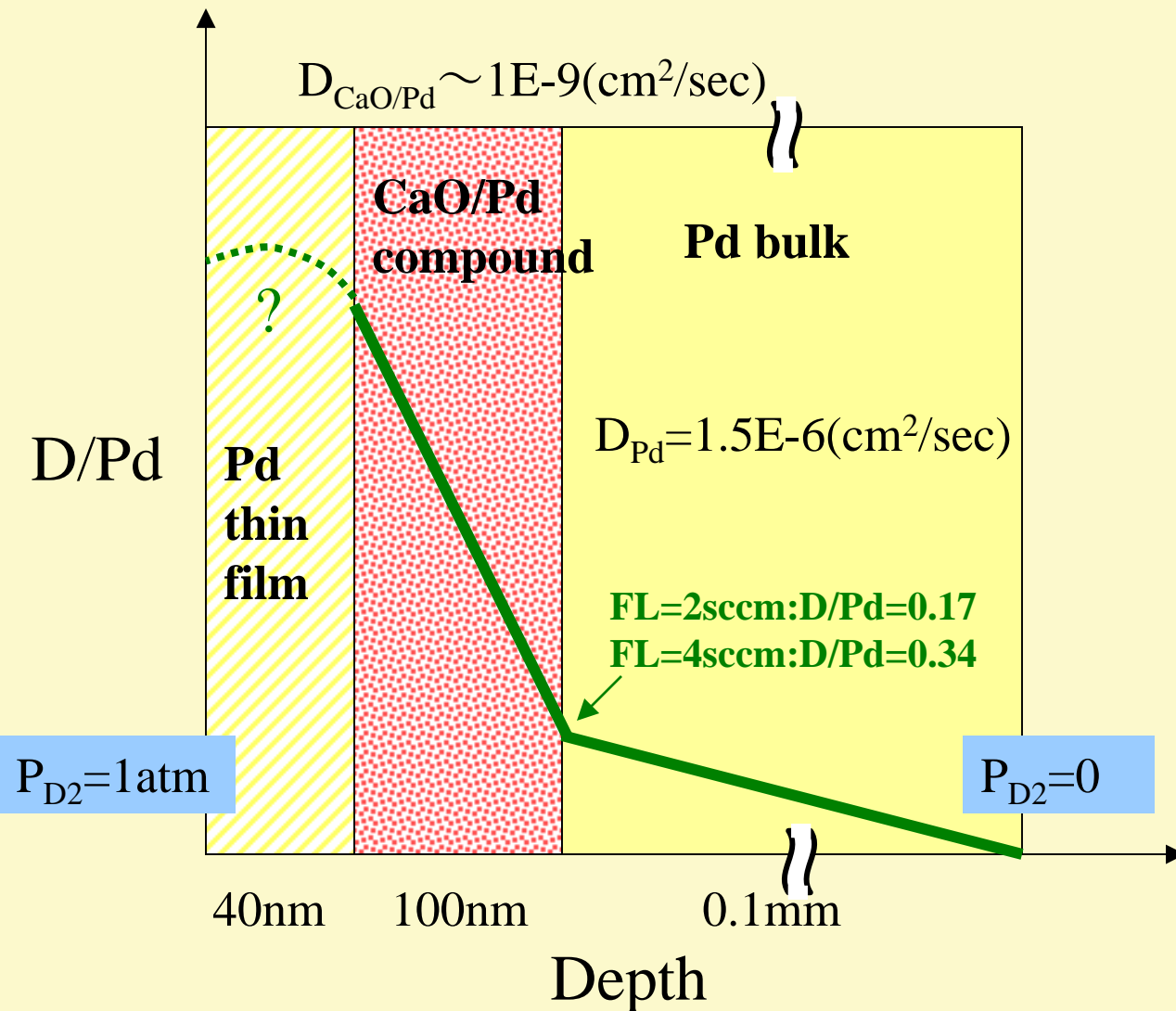


Mass Number

Transmutation Dependence on the Element Addition Method

<p>Pd Complex</p> 	 <p>1V</p> <p>Pd Complex Pt</p> <p>1mM CsNO₃/D₂O solution</p>	 <p>Cs + CsNO₃</p>	Positive
	 <p>Cs⁺</p> <p>Pd Complex</p>	 <p>Cs</p>	Positive
	 <p>CsNO₃ Drop</p>	 <p>CsNO₃</p>	Negative

Conjecture on D distribution in the Pd Complex



$$\frac{\partial C}{\partial t} = D \frac{\partial^2 C}{\partial x^2} \quad \frac{\partial}{\partial t} = 0$$

$$Q = A \cdot J = -A \cdot D \frac{\partial C}{\partial x}$$

$$-A \cdot D_{CaO/Pd} \cdot \frac{\partial C}{\partial x} \Big|_{CaO/Pd}$$

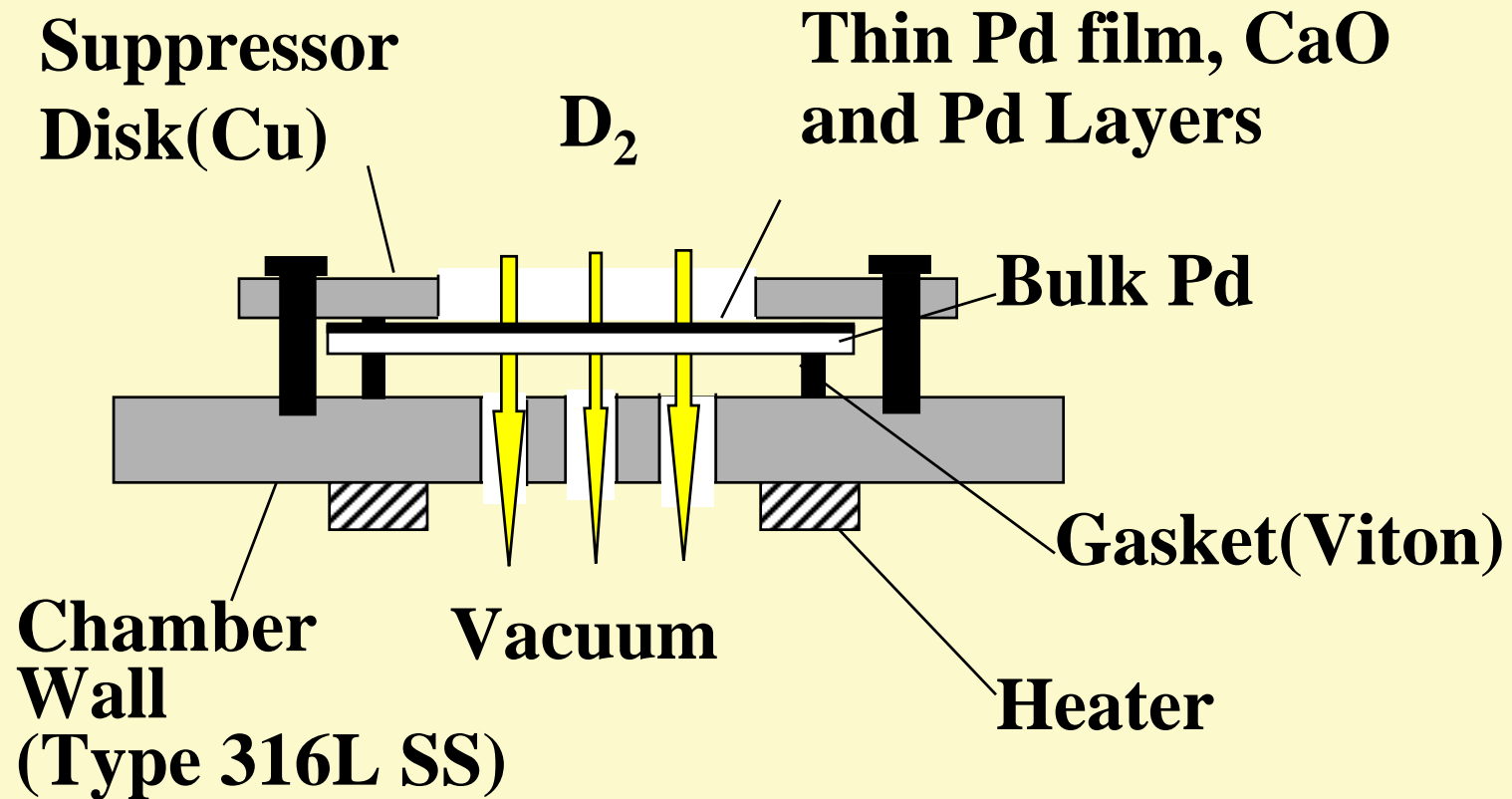
$$= -A \cdot D_{Pd} \cdot \frac{\partial C}{\partial x} \Big|_{Pd}$$

$$D_{CaO/Pd} \leq D_{Pd}$$

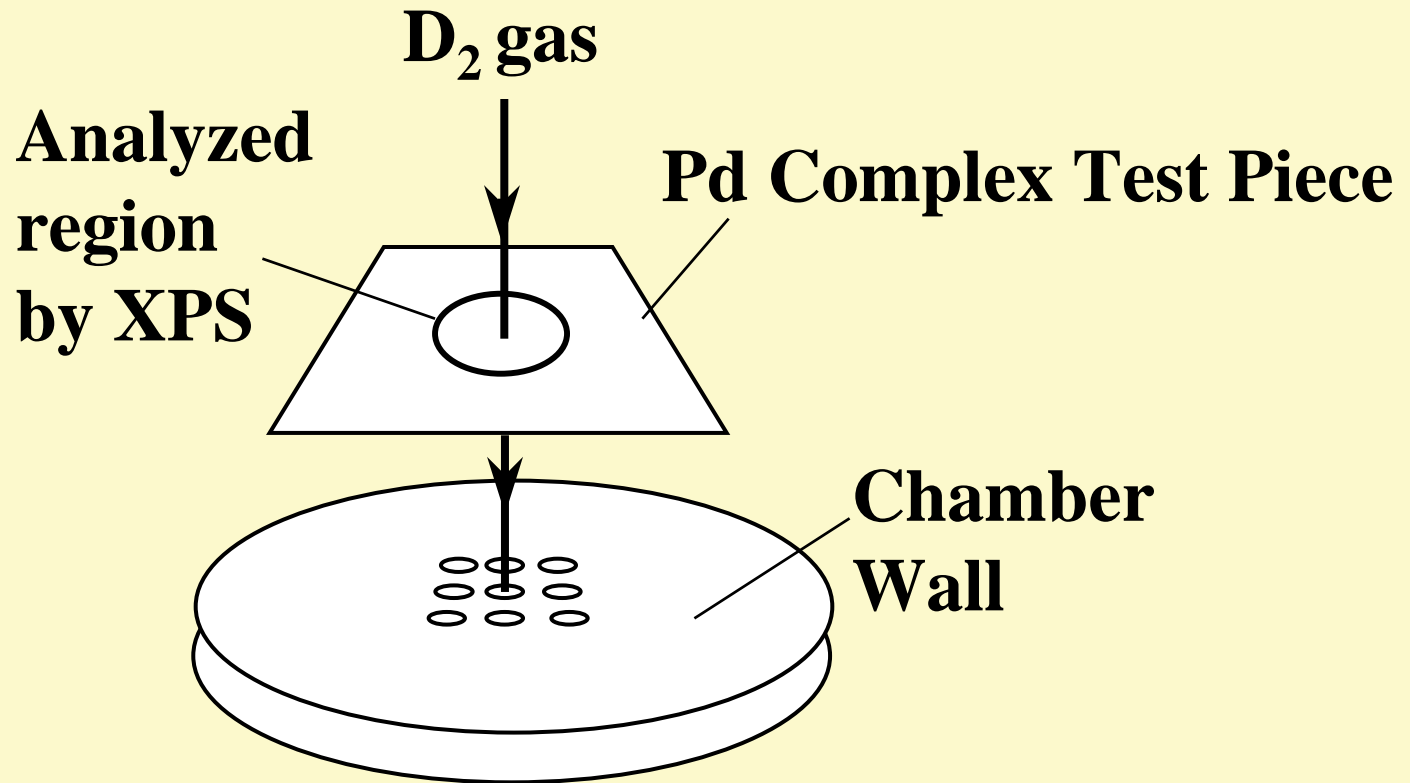


$$\frac{\partial C}{\partial x} \Big|_{CaO/Pd} \geq \frac{\partial C}{\partial x} \Big|_{Pd}$$

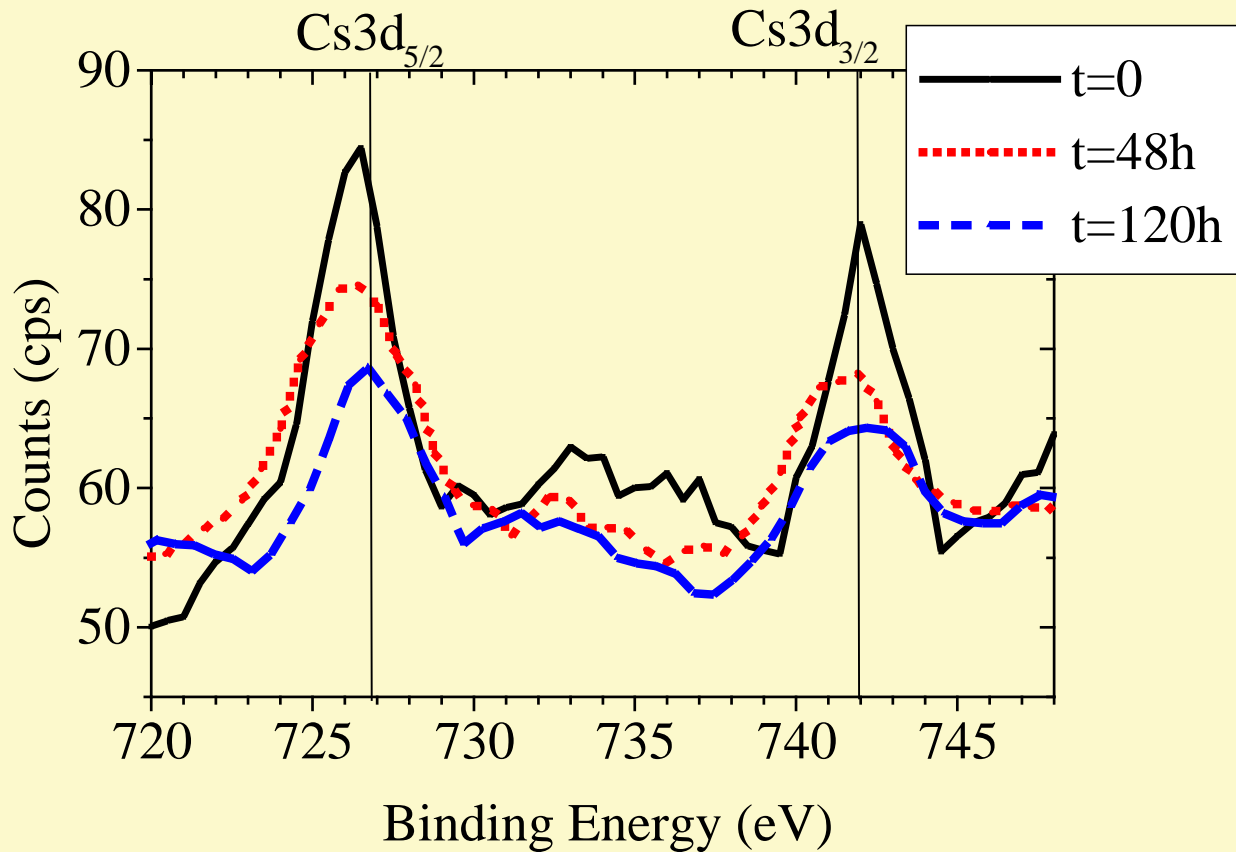
Cross Sectional View



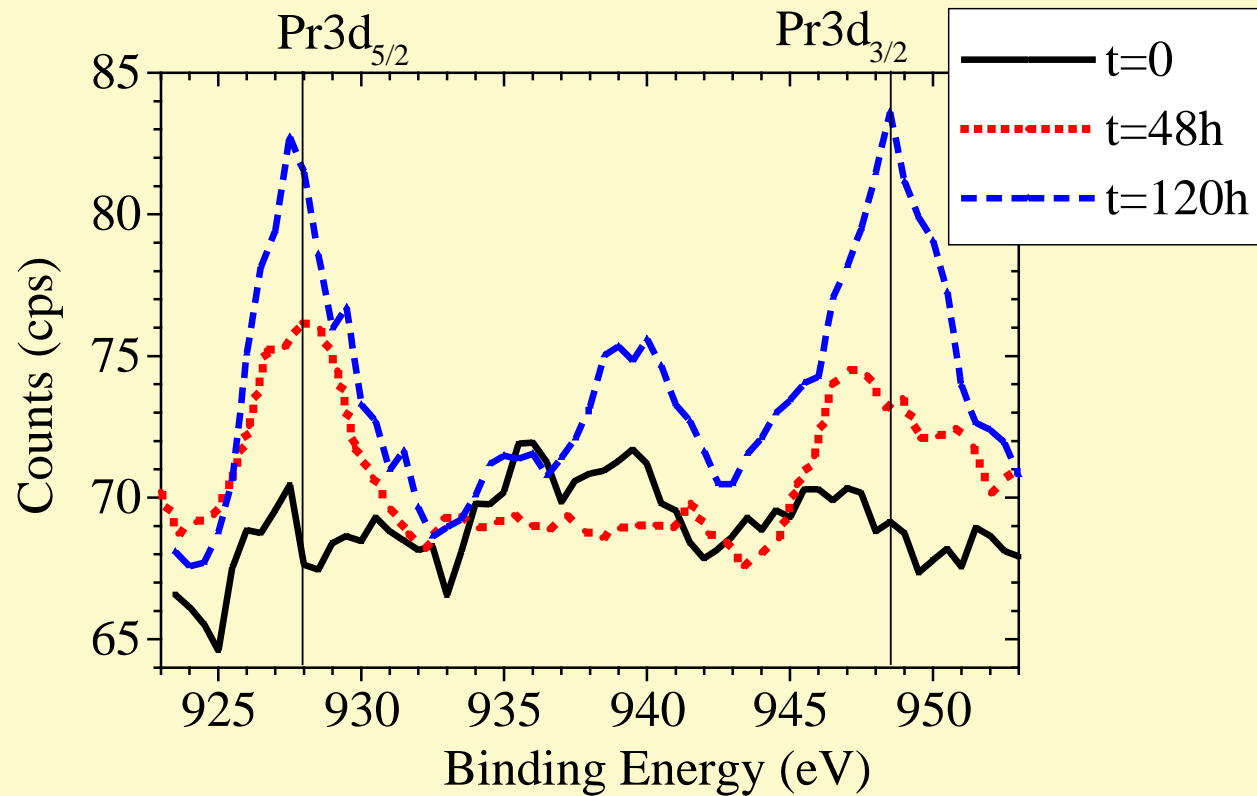
Passage of D₂ Gas



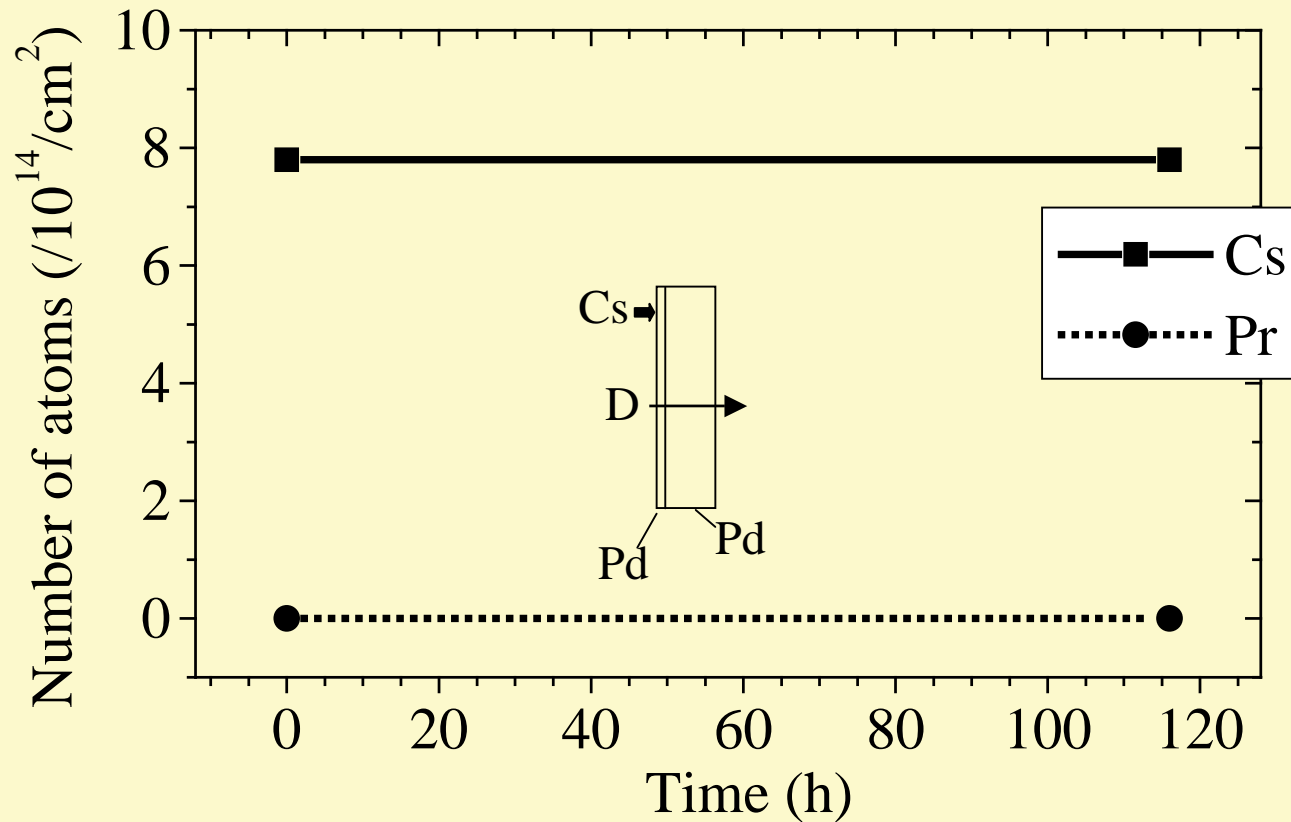
Change of XPS Spectrum of Cs



Change of XPS Spectrum of Pr

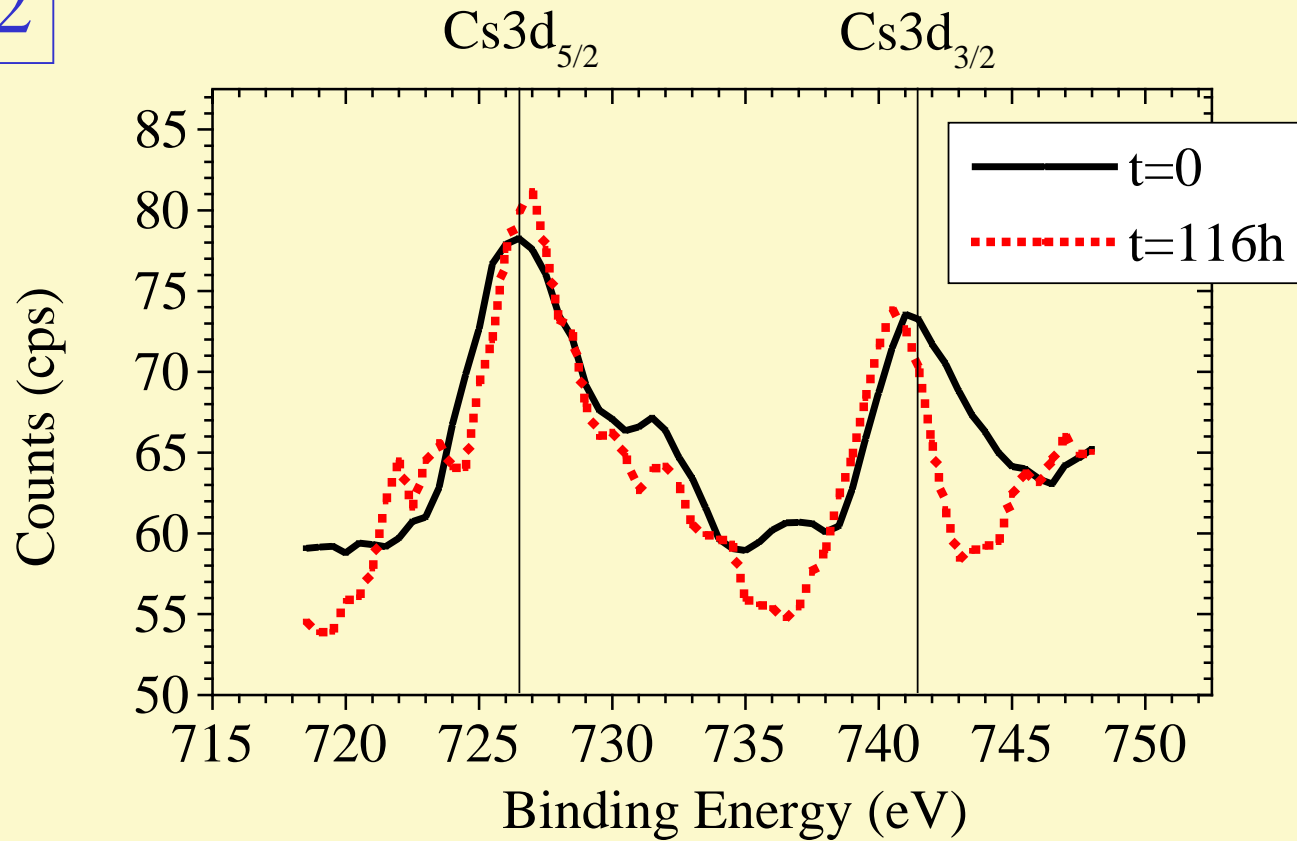


Time Variation in number of Cs and Pr atoms in the case of D₂ Permeation through thin film and bulk Pd with added Cs



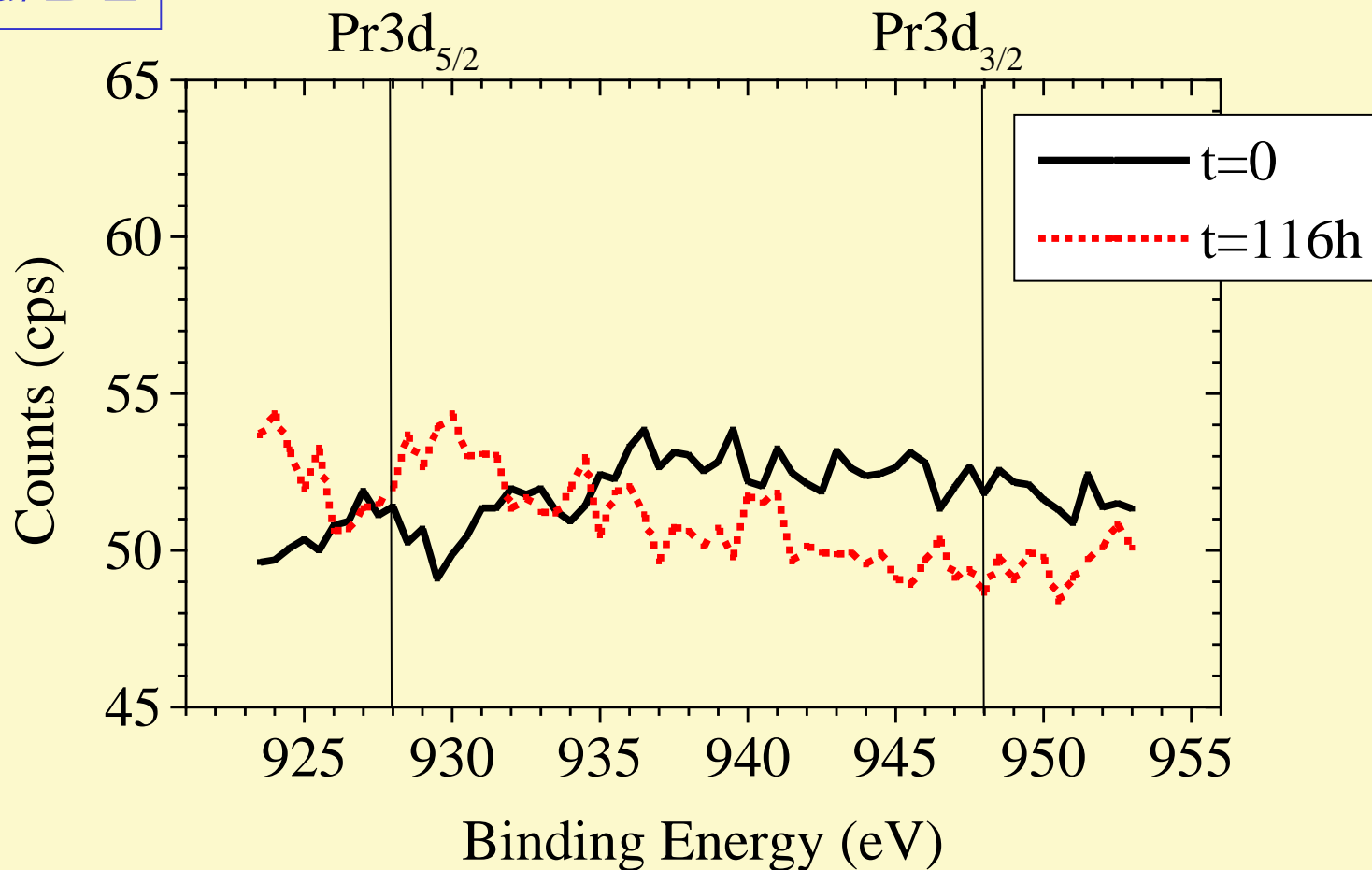
XPS Spectrum of Cs (No CaO)

Pd/Pd/D2

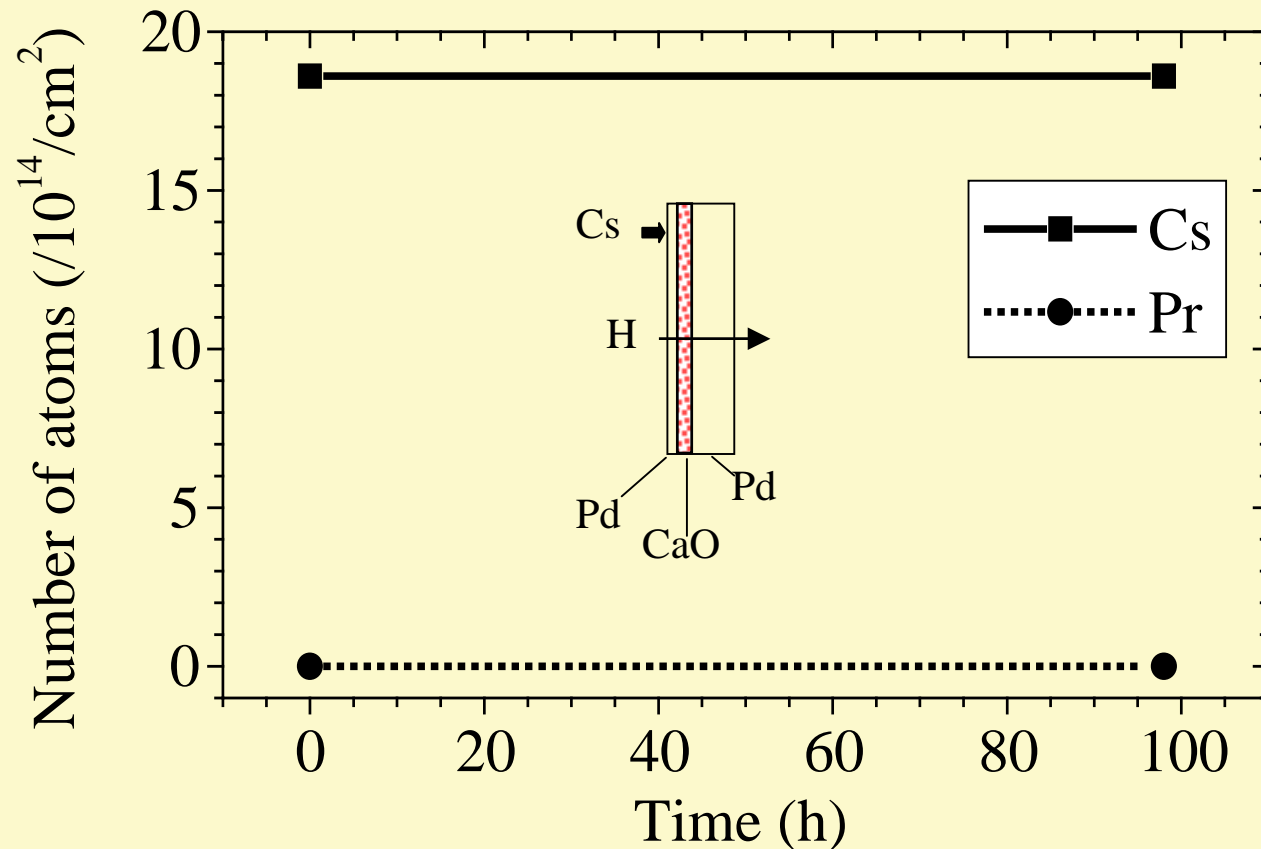


XPS Spectrum of Pr (No CaO)

Pd/Pd/D2

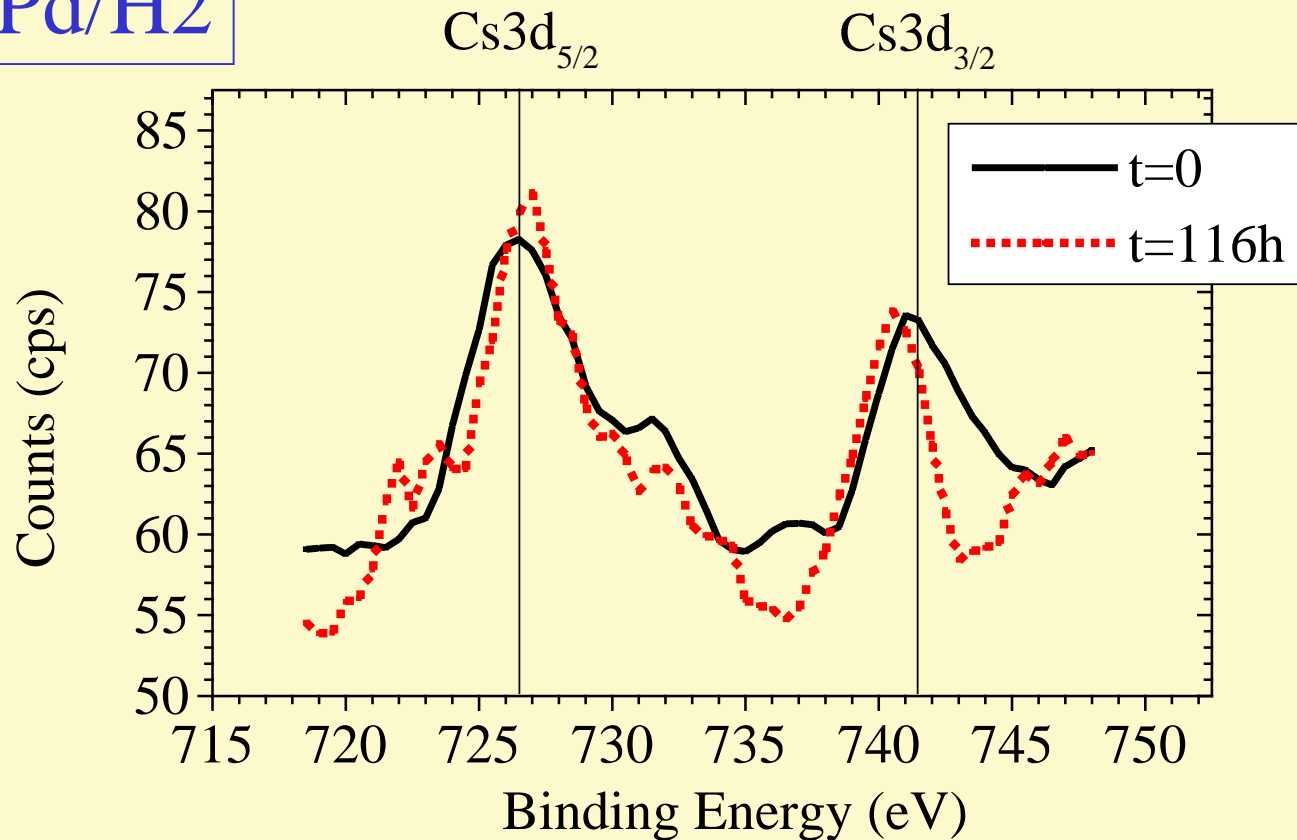


Time Variation in number of Cs and Pr atoms in the case of H₂ Permeation through Pd Complex with added Cs



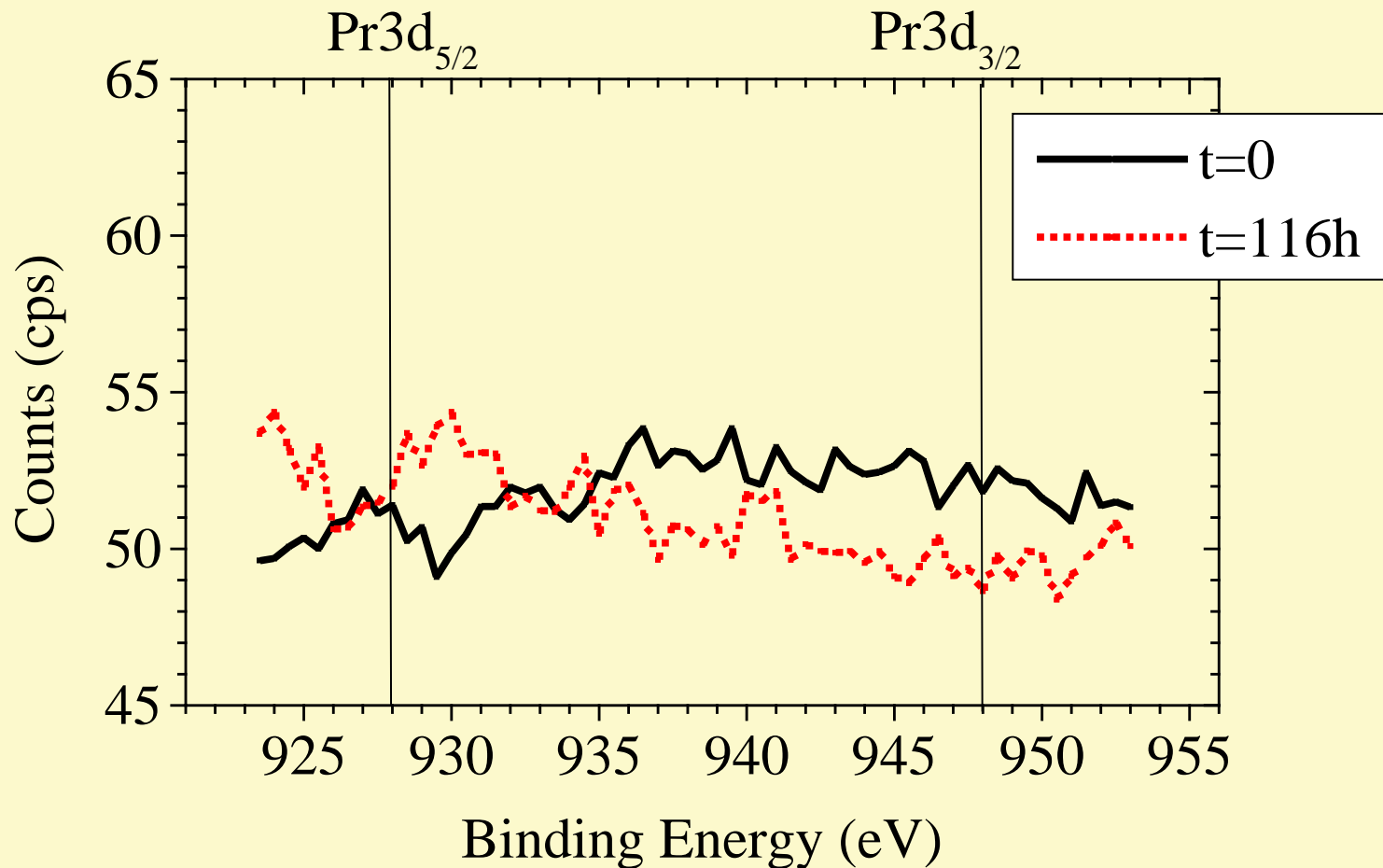
XPS Spectrum of Cs(H₂ Permeation)

Pd/CaO/Pd/H₂

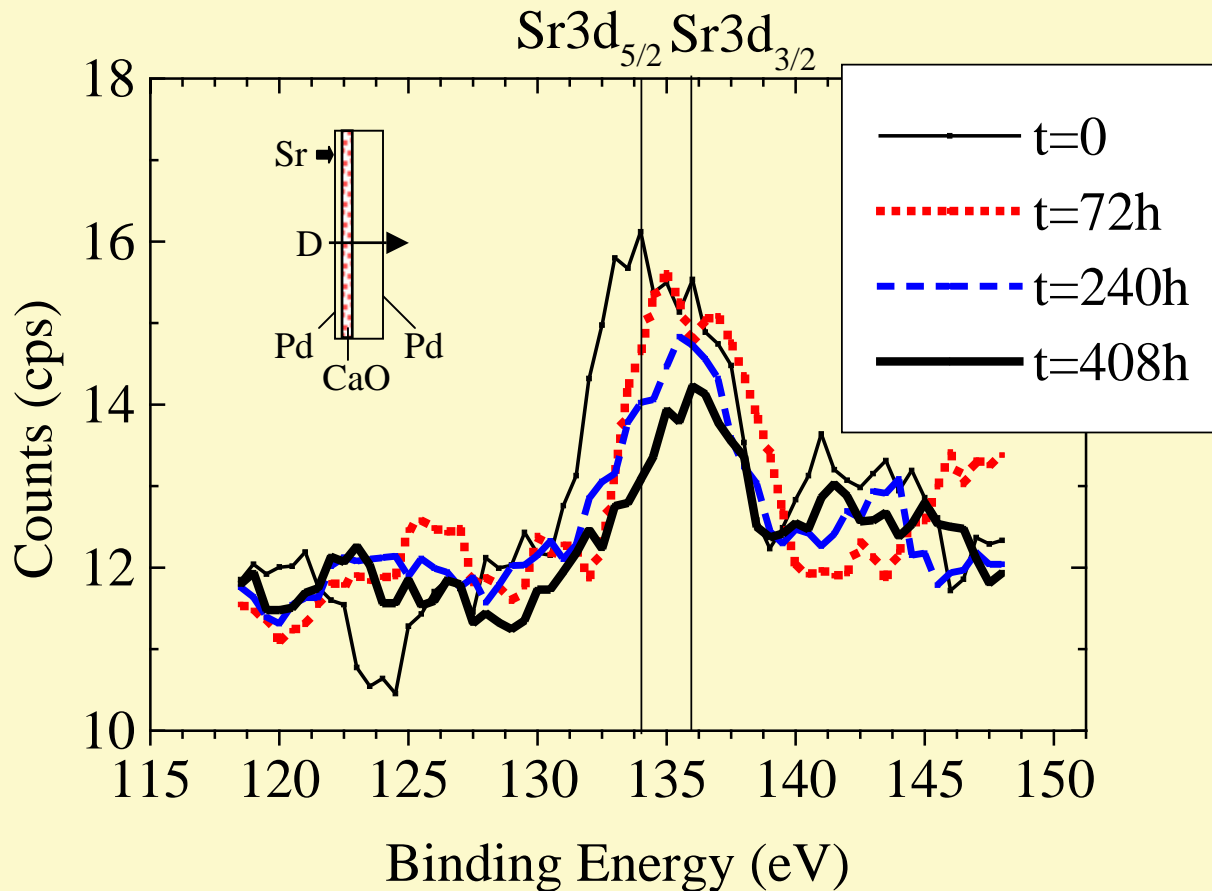


XPS Spectrum of Pr (H₂ Permeation)

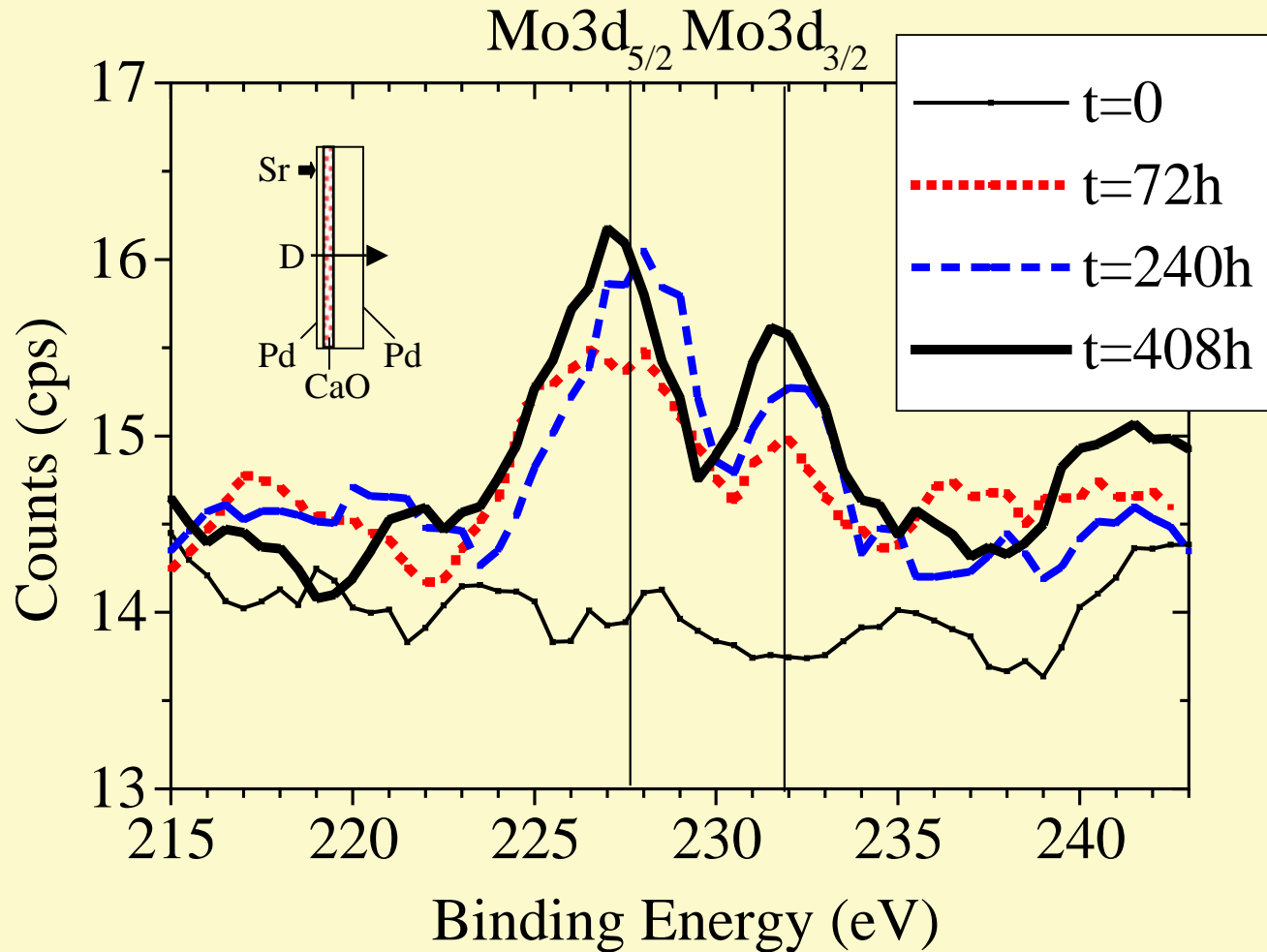
Pd/CaO/Pd/H₂



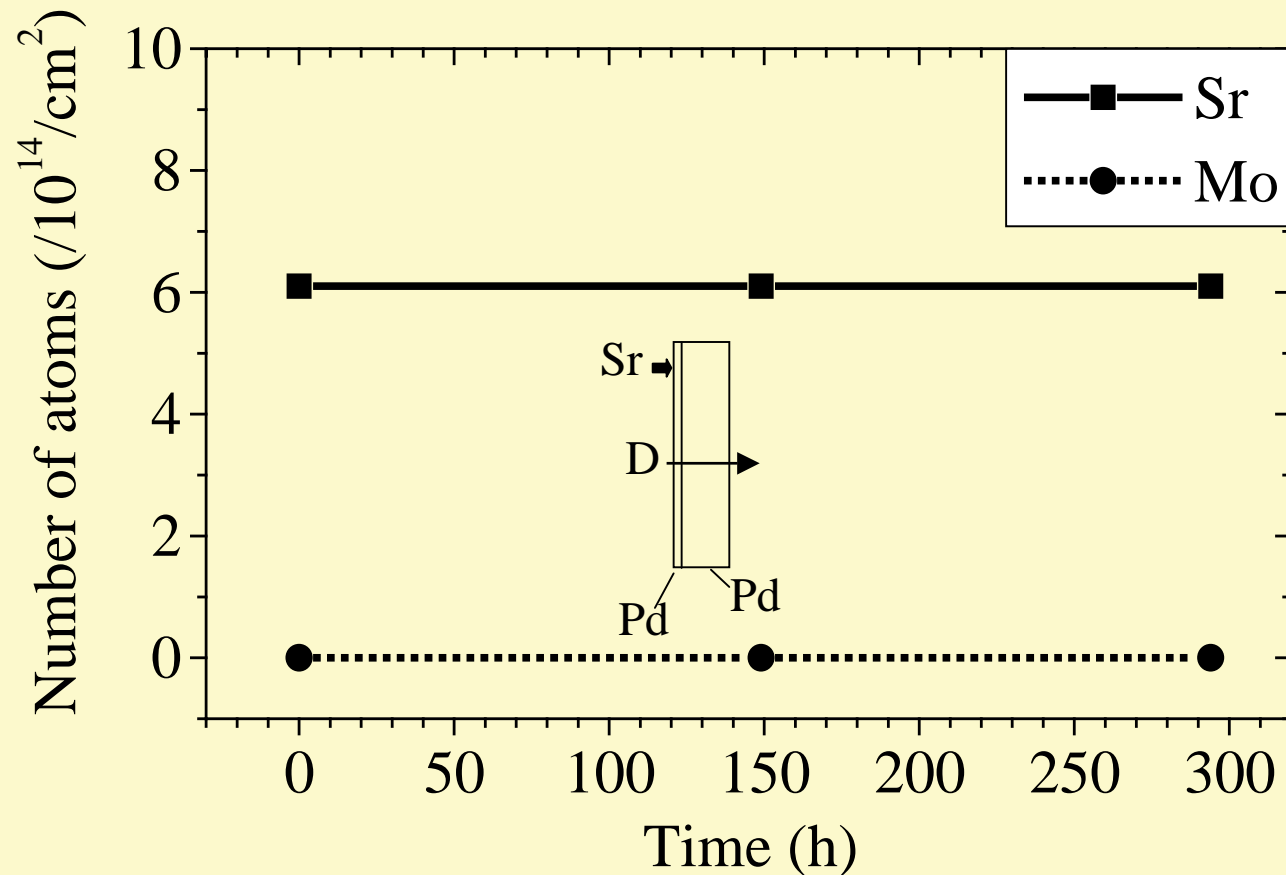
Change of XPS Spectrum of Sr



Change of XPS Spectrum of Mo

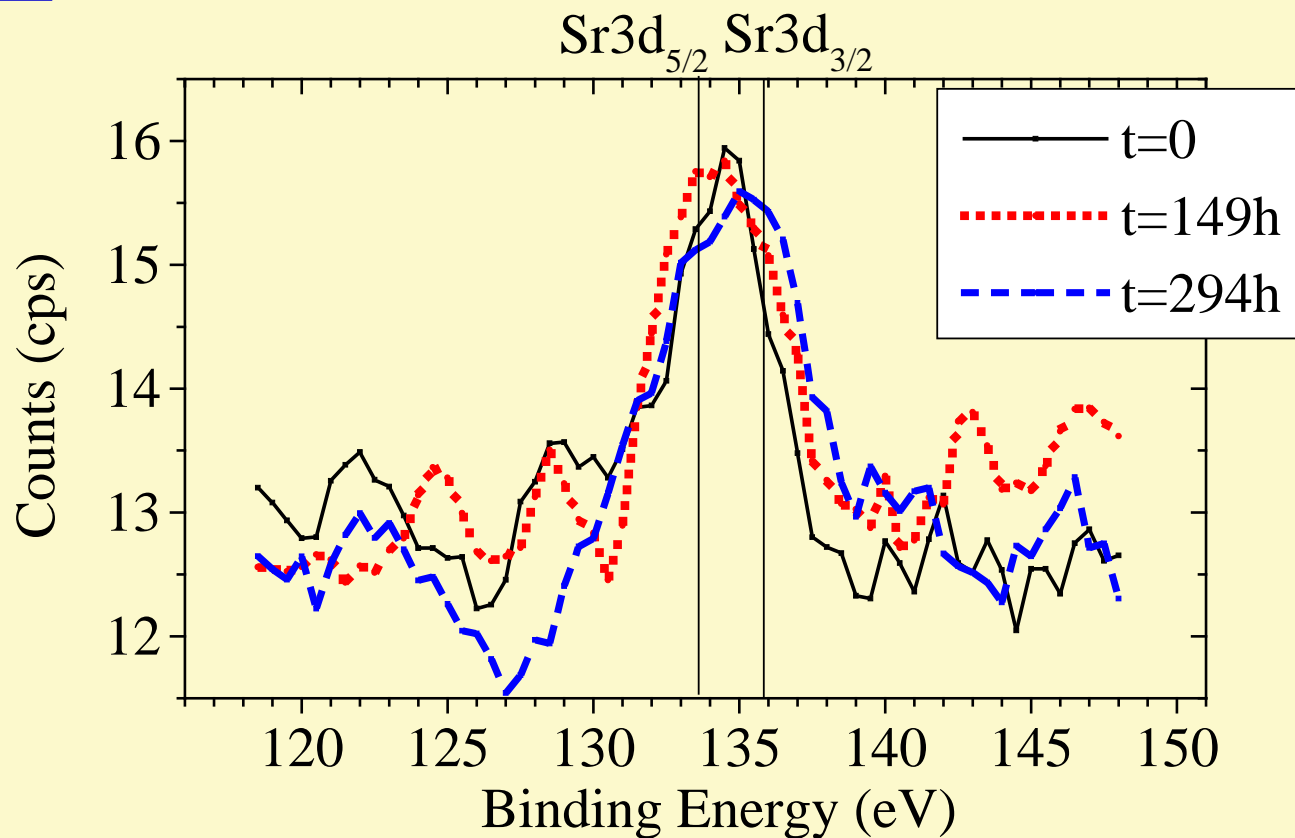


Time Variation in number of Sr and Mo atoms in the case of D₂ Permeation through thin film and bulk Pd with added Sr



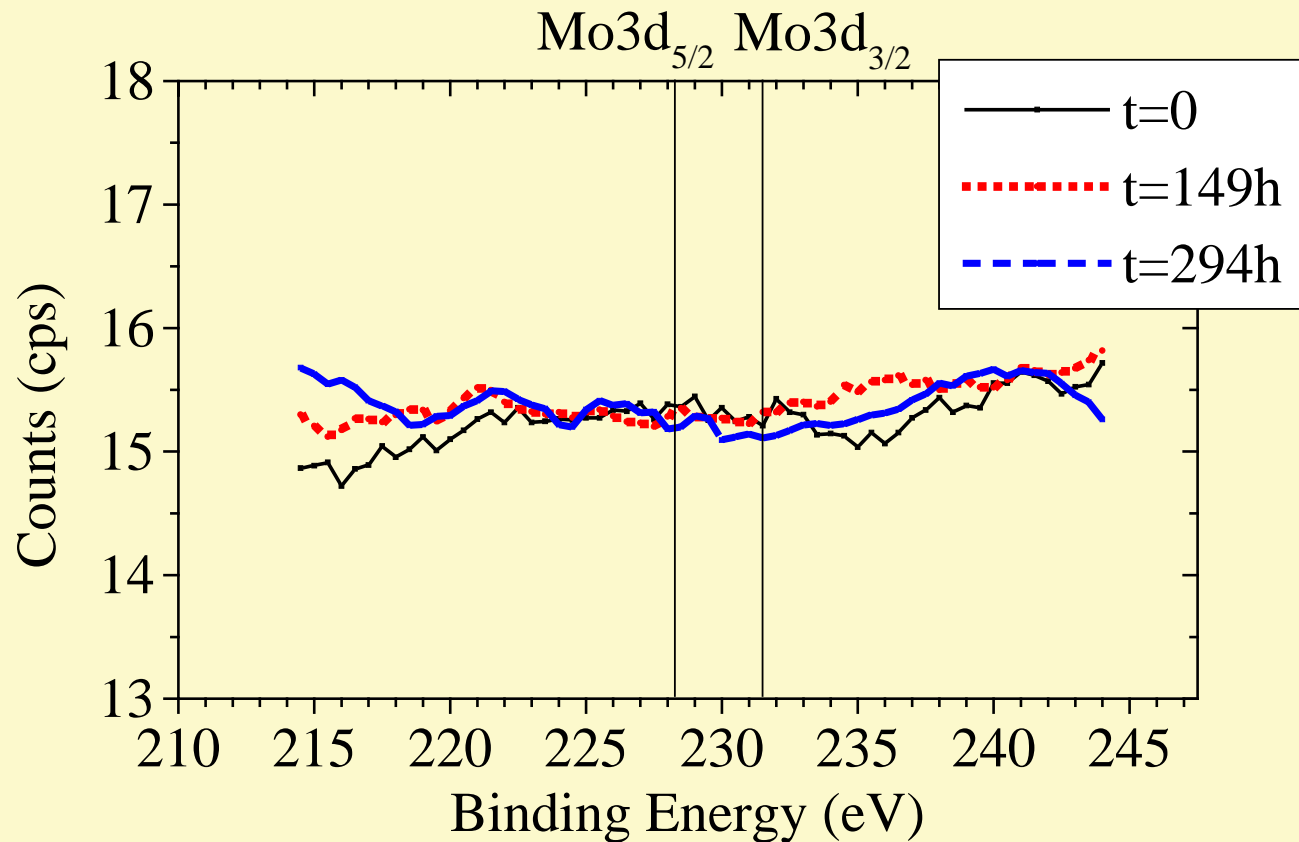
XPS Spectrum of Sr (No CaO)

Pd/Pd/D2

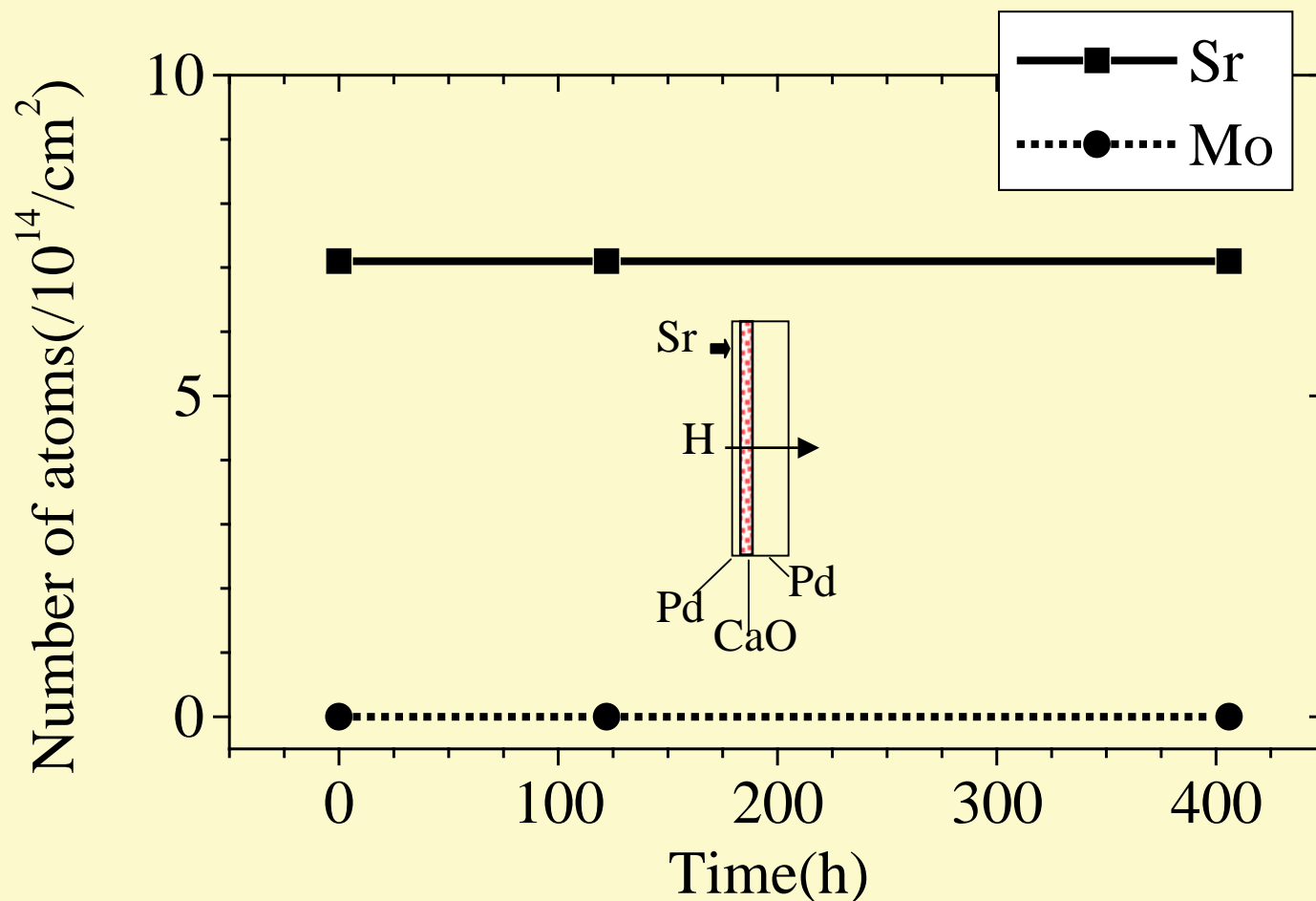


XPS Spectrum of Mo (No CaO)

Pd/Pd/D2

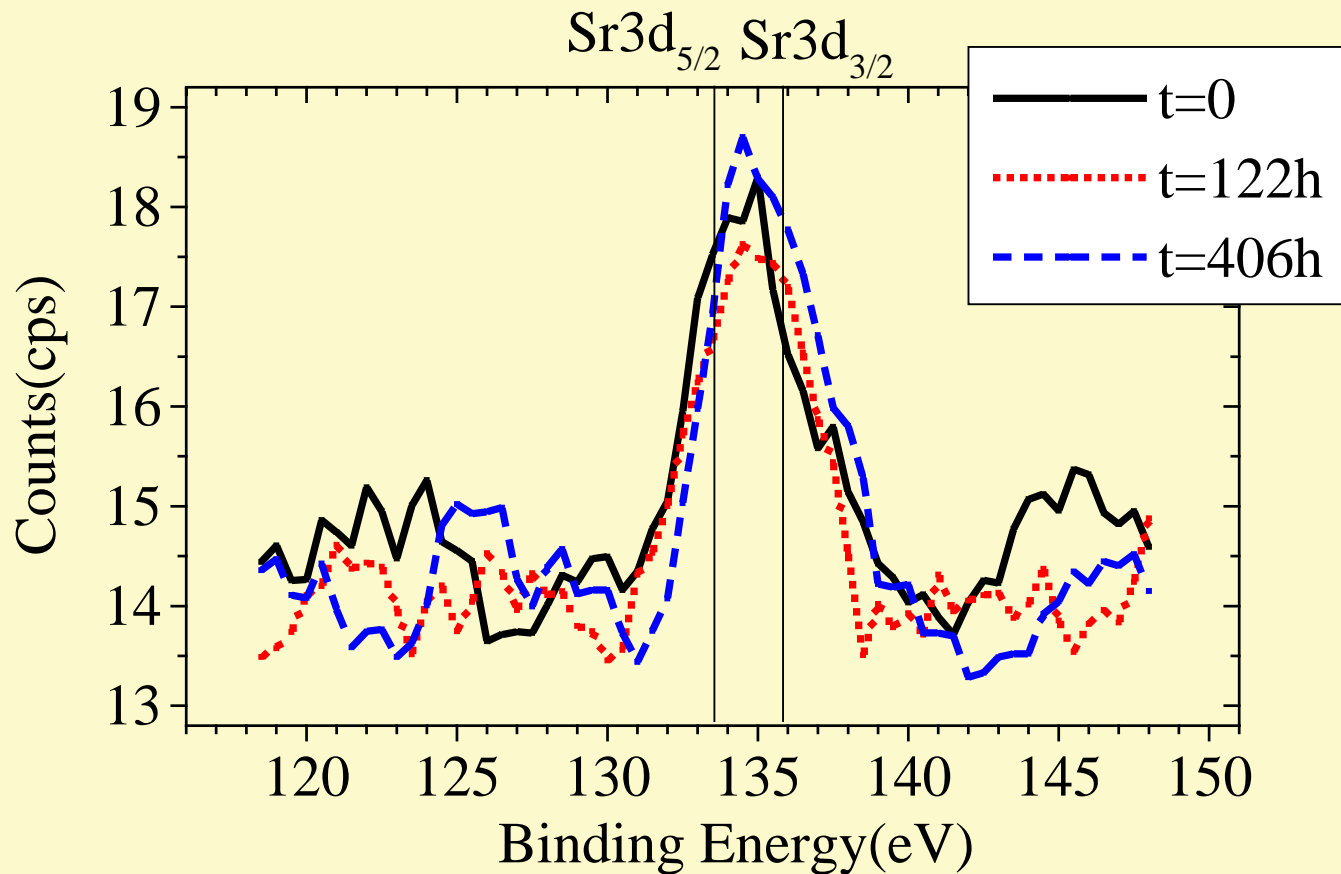


Time Variation in number of Sr and Mo atoms in the case of H₂ Permeation through Pd Complex with added Sr



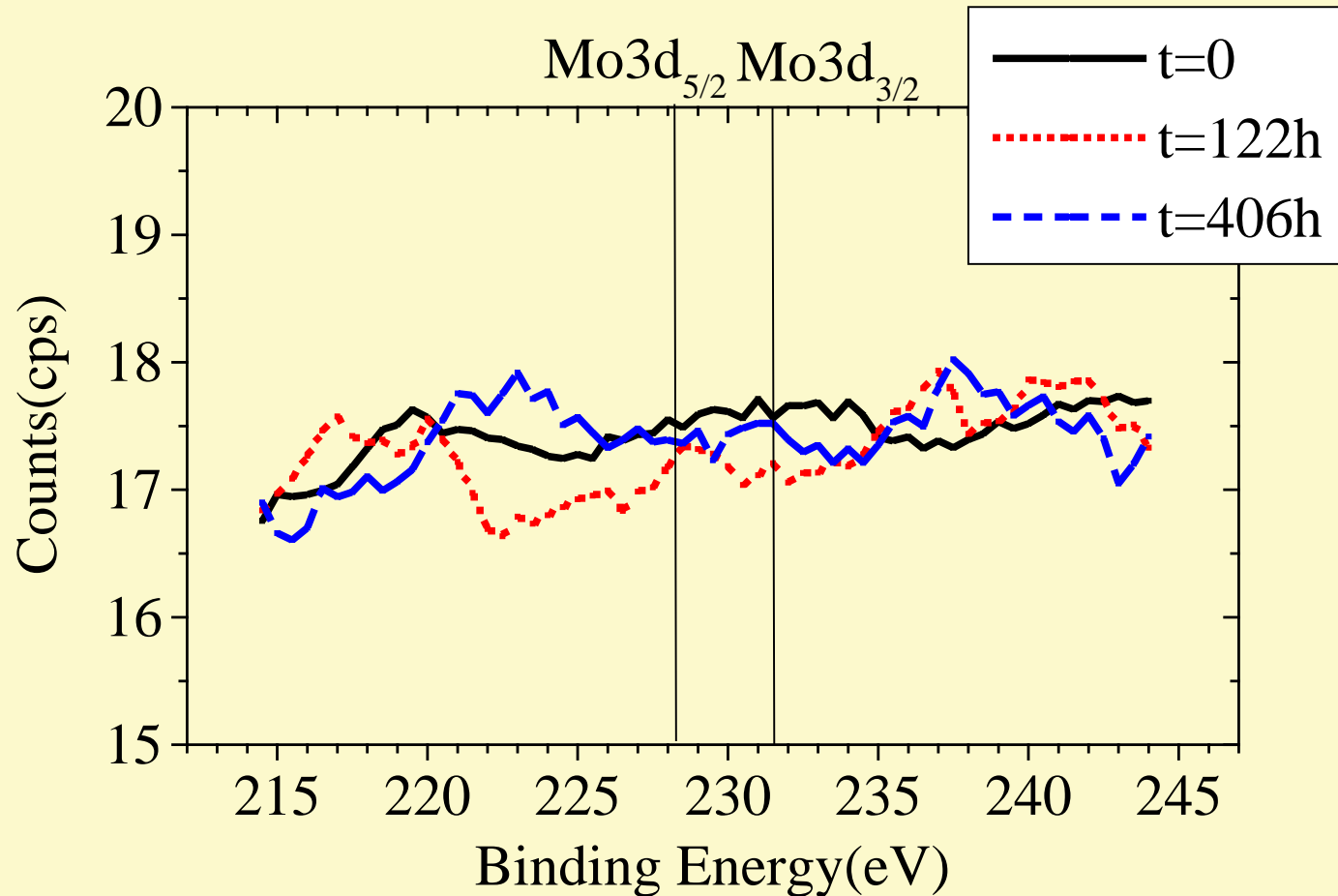
XPS Spectrum of Sr (H_2 Permeation)

Pd/CaO/Pd/ H_2



XPS Spectrum of Mo (H₂ Permeation)

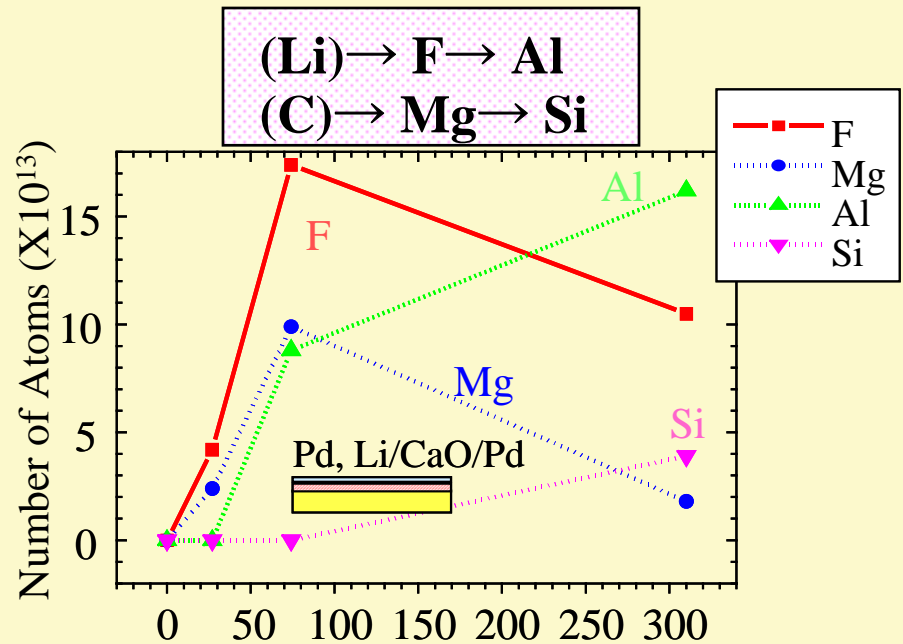
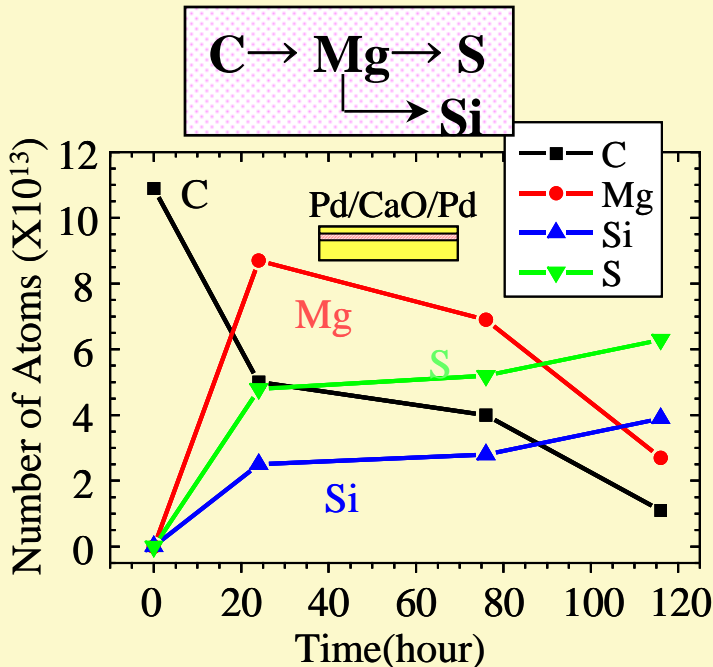
Pd/CaO/Pd/H₂



Separation of the Products and Contaminants(3)

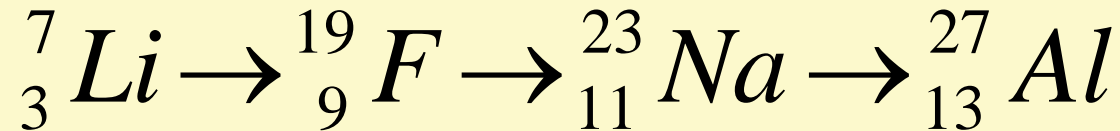
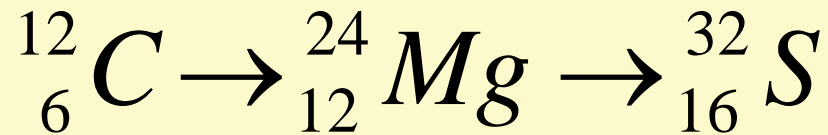
3. Variation of Detected Elements depending on the given Elements

Cs→Pr, Sr→Mo Li→Al, C→S,Si



If the detected elements were contaminants, was it possible that the detected elements changed depending on the given elements?

The other observations



Necessary Conditions

Necessary Conditions to Induce Low Energy Nuclear Reactions

- 1. Enough Deuterium Flux**
- 2. Sufficient D on the Pd surface**
- 3. Existence of a third element
except Pd and D**



Experimental Results